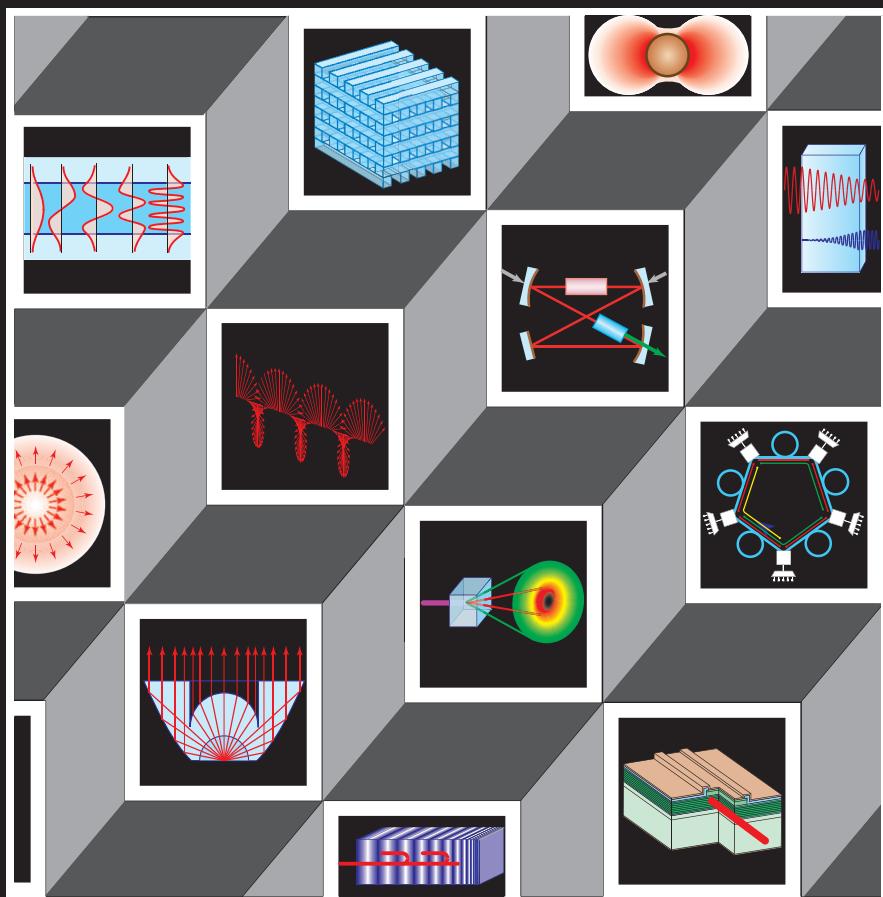


Wiley Series in Pure and Applied Optics

G. Boreman, Editor

FUNDAMENTALS OF **PHOTONICS**



Third Edition

**B. E. A. Saleh
M. C. Teich**

WILEY

FUNDAMENTALS OF PHOTONICS

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THIRD EDITION

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CONTENTS

PREFACE TO THE THIRD EDITION	xii
PREFACE TO THE SECOND EDITION	xx
PREFACE TO THE FIRST EDITION	xxiii
PART I: OPTICS	
1 RAY OPTICS	3
1.1 Postulates of Ray Optics	5
1.2 Simple Optical Components	8
1.3 Graded-Index Optics	20
1.4 Matrix Optics	27
Reading List	37
Problems	38
2 WAVE OPTICS	41
2.1 Postulates of Wave Optics	43
2.2 Monochromatic Waves	44
*2.3 Relation Between Wave Optics and Ray Optics	52
2.4 Simple Optical Components	53
2.5 Interference	61
2.6 Polychromatic and Pulsed Light	71
Reading List	76
Problems	77
3 BEAM OPTICS	79
3.1 The Gaussian Beam	80
3.2 Transmission Through Optical Components	91
3.3 Hermite–Gaussian Beams	99
3.4 Laguerre–Gaussian Beams	102
3.5 Nondiffracting Beams	105
Reading List	108
Problems	108
4 FOURIER OPTICS	110
4.1 Propagation of Light in Free Space	113
4.2 Optical Fourier Transform	124
4.3 Diffraction of Light	129
4.4 Image Formation	137
4.5 Holography	147
Reading List	155
Problems	157

5	ELECTROMAGNETIC OPTICS	160
5.1	Electromagnetic Theory of Light	162
5.2	Electromagnetic Waves in Dielectric Media	166
5.3	Monochromatic Electromagnetic Waves	172
5.4	Elementary Electromagnetic Waves	175
5.5	Absorption and Dispersion	181
5.6	Scattering of Electromagnetic Waves	192
5.7	Pulse Propagation in Dispersive Media	199
	Reading List	205
	Problems	207
6	POLARIZATION OPTICS	209
6.1	Polarization of Light	211
6.2	Reflection and Refraction	221
6.3	Optics of Anisotropic Media	227
6.4	Optical Activity and Magneto-Optics	240
6.5	Optics of Liquid Crystals	244
6.6	Polarization Devices	247
	Reading List	251
	Problems	252
7	PHOTONIC-CRYSTAL OPTICS	255
7.1	Optics of Dielectric Layered Media	258
7.2	One-Dimensional Photonic Crystals	277
7.3	Two- and Three-Dimensional Photonic Crystals	291
	Reading List	299
	Problems	301
8	METAL AND METAMATERIAL OPTICS	303
8.1	Single- and Double-Negative Media	306
8.2	Metal Optics: Plasmonics	320
8.3	Metamaterial Optics	334
*8.4	Transformation Optics	343
	Reading List	349
	Problems	351
9	GUIDED-WAVE OPTICS	353
9.1	Planar-Mirror Waveguides	355
9.2	Planar Dielectric Waveguides	363
9.3	Two-Dimensional Waveguides	372
9.4	Optical Coupling in Waveguides	376
9.5	Photonic-Crystal Waveguides	385
9.6	Plasmonic Waveguides	386
	Reading List	389
	Problems	389
10	FIBER OPTICS	391
10.1	Guided Rays	393
10.2	Guided Waves	397
10.3	Attenuation and Dispersion	415
10.4	Holey and Photonic-Crystal Fibers	426
10.5	Fiber Materials	429
	Reading List	430
	Problems	432

11 RESONATOR OPTICS	433
11.1 Planar-Mirror Resonators	436
11.2 Spherical-Mirror Resonators	447
11.3 Two- and Three-Dimensional Resonators	459
11.4 Microresonators and Nanoresonators	463
Reading List	470
Problems	471
12 STATISTICAL OPTICS	473
12.1 Statistical Properties of Random Light	475
12.2 Interference of Partially Coherent Light	489
*12.3 Transmission of Partially Coherent Light	497
12.4 Partial Polarization	506
Reading List	510
Problems	512
13 PHOTON OPTICS	514
13.1 The Photon	516
13.2 Photon Streams	529
*13.3 Quantum States of Light	541
Reading List	550
Problems	554
PART II: PHOTONICS	559
14 LIGHT AND MATTER	561
14.1 Energy Levels	562
14.2 Occupation of Energy Levels	581
14.3 Interactions of Photons with Atoms	583
14.4 Thermal Light	602
14.5 Luminescence and Scattering	607
Reading List	614
Problems	617
15 LASER AMPLIFIERS	619
15.1 Theory of Laser Amplification	622
15.2 Amplifier Pumping	626
15.3 Representative Laser Amplifiers	636
15.4 Amplifier Nonlinearity	645
*15.5 Amplifier Noise	651
Reading List	653
Problems	655
16 LASERS	657
16.1 Theory of Laser Oscillation	659
16.2 Characteristics of the Laser Output	666
16.3 Types of Lasers	680
16.4 Pulsed Lasers	707
Reading List	723
Problems	728

17 SEMICONDUCTOR OPTICS	731
17.1 Semiconductors	733
17.2 Interactions of Photons with Charge Carriers	766
Reading List	782
Problems	784
18 LEDS AND LASER DIODES	787
18.1 Light-Emitting Diodes	789
18.2 Semiconductor Optical Amplifiers	817
18.3 Laser Diodes	831
18.4 Quantum-Confining Lasers	844
18.5 Microcavity Lasers	854
18.6 Nanocavity Lasers	862
Reading List	864
Problems	868
19 PHOTODETECTORS	871
19.1 Photodetectors	873
19.2 Photoconductors	883
19.3 Photodiodes	887
19.4 Avalanche Photodiodes	895
19.5 Array Detectors	907
19.6 Noise in Photodetectors	909
Reading List	935
Problems	938
20 ACOUSTO-OPTICS	943
20.1 Interaction of Light and Sound	945
20.2 Acousto-Optic Devices	958
*20.3 Acousto-Optics of Anisotropic Media	967
Reading List	972
Problems	972
21 ELECTRO-OPTICS	975
21.1 Principles of Electro-Optics	977
*21.2 Electro-Optics of Anisotropic Media	989
21.3 Electro-Optics of Liquid Crystals	996
*21.4 Photorefractivity	1005
21.5 Electroabsorption	1010
Reading List	1012
Problems	1013
22 NONLINEAR OPTICS	1015
22.1 Nonlinear Optical Media	1017
22.2 Second-Order Nonlinear Optics	1021
22.3 Third-Order Nonlinear Optics	1036
*22.4 Second-Order Nonlinear Optics: Coupled Waves	1047
*22.5 Third-Order Nonlinear Optics: Coupled Waves	1059
*22.6 Anisotropic Nonlinear Media	1066
*22.7 Dispersive Nonlinear Media	1069
Reading List	1074
Problems	1075

23 ULTRAFAST OPTICS	1078
23.1 Pulse Characteristics	1079
23.2 Pulse Shaping and Compression	1088
23.3 Pulse Propagation in Optical Fibers	1102
23.4 Ultrafast Linear Optics	1115
23.5 Ultrafast Nonlinear Optics	1126
23.6 Pulse Detection	1146
Reading List	1159
Problems	1161
24 OPTICAL INTERCONNECTS AND SWITCHES	1163
24.1 Optical Interconnects	1166
24.2 Passive Optical Routers	1178
24.3 Photonic Switches	1187
24.4 Photonic Logic Gates	1211
Reading List	1220
Problems	1222
25 OPTICAL FIBER COMMUNICATIONS	1224
25.1 Fiber-Optic Components	1226
25.2 Optical Fiber Communication Systems	1238
25.3 Modulation and Multiplexing	1257
25.4 Coherent Optical Communications	1266
25.5 Fiber-Optic Networks	1274
Reading List	1281
Problems	1284
A FOURIER TRANSFORM	1287
A.1 One-Dimensional Fourier Transform	1287
A.2 Time Duration and Spectral Width	1290
A.3 Two-Dimensional Fourier Transform	1293
Reading List	1295
B LINEAR SYSTEMS	1296
B.1 One-Dimensional Linear Systems	1296
B.2 Two-Dimensional Linear Systems	1299
Reading List	1300
C MODES OF LINEAR SYSTEMS	1301
Reading List	1305
SYMBOLS AND UNITS	1306
AUTHORS	1331
INDEX	1333

PREFACE TO THE THIRD EDITION

Since the publication of the *Second Edition* in 2007, *Fundamentals of Photonics* has maintained its worldwide prominence as a self-contained, up-to-date, introductory-level textbook that features a blend of theory and applications. It has been reprinted dozens of times and been translated into German and Chinese, as well as Czech and Japanese. The Third Edition incorporates many of the scientific and technological developments in photonics that have taken place in the past decade and strives to be cutting-edge.

Optics and Photonics

Before usage of the term photonics became commonplace at the time of the *First Edition* in the early 1990s, the field was characterized by a collection of appellations that were not always clearly delineated. Terms such as quantum electronics, optoelectronics, electro-optics, and lightwave technology were widely used. Though there was a lack of agreement about the precise meanings of these terms, there was nevertheless a vague consensus regarding their usage. Most of these terms have since receded from general use, although some have retained their presence in the titles of technical journals and academic courses.

Now, more than 25 years later, the term *Optics* along with the term *Photonics*, as well as their combination *Optics & Photonics*, have prevailed. The distinction between optics and photonics remains somewhat fuzzy, however, and there is a degree of overlap between the two arenas. Hence, there is some arbitrariness in the manner in which the chapters of this book are allocated to its two volumes, *Part I: Optics* and *Part II: Photonics*. From a broad perspective, the term *Optics* is taken to signify free-space and guided-wave propagation, and to include topics such as interference, diffraction, imaging, statistical optics, and photon optics. The term *Photonics*, in contrast, is understood to include topics that rely on the interaction of light and matter, and is dedicated to the study of devices and systems. As the miniaturization of components and systems continues to progress and foster emerging technologies such as nanophotonics and biophotonics, the importance of photonics continues to advance.

Printed and Electronic Versions

The *Third Edition* appears in four versions:

1. A printed version.
2. An eBook in the form of an ePDF file that mimics the printed version.
3. An eBook in the form of a standard ePUB.
4. An eBook in the form of an enhanced ePUB with animations for selected figures.

In its *printed* form, the text consists of two volumes, each of which contains the Table of Contents and Index for both volumes along with the Appendices and List of Symbols:

- *Part I: Optics*, contains the first thirteen chapters.
- *Part II: Photonics*, contains the remaining twelve chapters.

The material in the eBook versions is identical to that in the printed version except that all 25 chapters reside in a single electronic file. The various *eBooks* enjoy the following features:

- Hyperlinked table of contents at the beginning of the text.

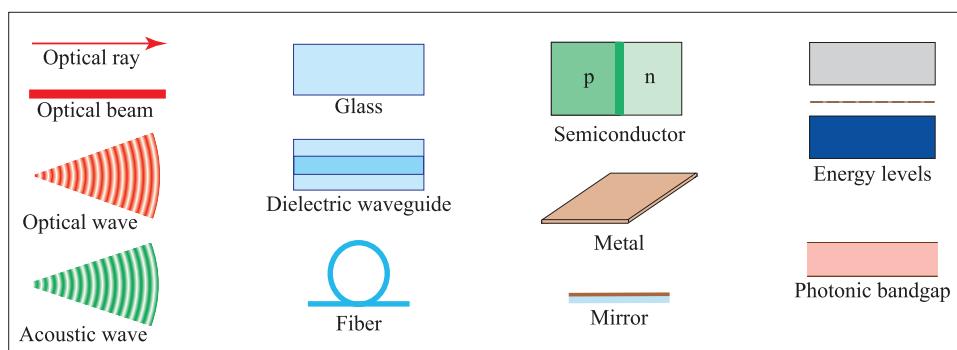
- Hyperlinked table of contents as an optional sidebar.
- Hyperlinked index.
- Hyperlinked section titles, equations, and figures throughout.
- Animations for selected figures in the enhanced ePUB.

Presentation

Exercises, examples, reading lists, and appendices. Each chapter of the *Third Edition* contains exercises, problem sets, and an extensive reading list. Examples are included throughout to emphasize the concepts governing applications of current interest. Appendices summarize the properties of one- and two-dimensional Fourier transforms, linear systems, and modes of linear systems. Important equations are highlighted by boxes and labels to facilitate retrieval.

Symbols, notation, units, and conventions. We make use of the symbols, notation, units, and conventions commonly used in the photonics literature. Because of the broad spectrum of topics covered, different fonts are often used to delineate the multiple meanings of various symbols; a list of symbols, units, abbreviations, and acronyms follows the appendices. We adhere to the International System of Units (SI units). This modern form of the metric system is based on the meter, kilogram, second, ampere, kelvin, candela, and mole, and is coupled with a collection of prefixes (specified on the inside back cover of the text) that indicate multiplication or division by various powers of ten. However, the reader is cautioned that photonics in the service of different areas of science can make use of different conventions and symbols. In Chapter 2, for example, we write the complex wavefunction for a monochromatic plane wave in a form commonly used in electrical engineering, which differs from that used in physics. Another example arises in Chapter 6, where the definitions we use for right (left) circularly polarized light are in accord with general usage in optics, but are opposite those generally used in engineering. These distinctions are often highlighted by *in situ* footnotes. Though the choice of a particular convention is manifested in the form assumed by various equations, it does not of course affect the results.

Color coding of illustrations. The color code used in illustrations is summarized in the chart presented below. Light beams and optical-field distributions are displayed in red (except when light beams of multiple wavelengths are involved, as is often the case in nonlinear optics). When optical fields are represented, white indicates negative values but when intensity is portrayed, white indicates zero. Acoustic beams and fields are similarly represented, but by with green rather than red. Glass and glass fibers are depicted in light blue; darker shades represent larger refractive indices. Semiconductors are cast in green, with various shades representing different doping levels. Metal and mirrors are indicated as copper. Semiconductor energy-band diagrams are portrayed in blue and gray whereas photonic bandgaps are illustrated in pink.



Color chart

Intended Audience

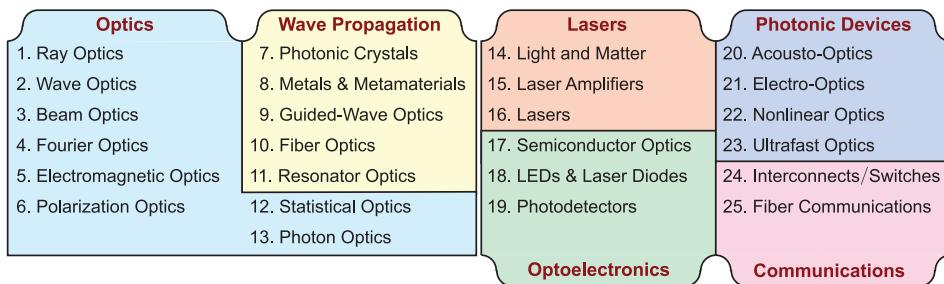
As with the previous editions, the *Third Edition* is meant to serve as:

- An introductory textbook for students of electrical engineering, applied physics, physics, or optics at the senior or first-year graduate level.
- A self-contained work for self-study.
- A textbook suitable for use in programs of continuing professional development offered by industry, universities, and professional societies.

The reader is assumed to have a background in engineering, physics, or optics, including courses in modern physics, electricity and magnetism, and wave motion. Some knowledge of linear systems and elementary quantum mechanics is helpful but not essential. The intent is to provide an introduction to optics and photonics that emphasizes the concepts that govern applications of current interest. The book should therefore not be considered as a compendium encompassing all photonic devices and systems. Indeed, some areas of photonics are not included at all, and many of the individual chapters could easily have been expanded into free-standing monographs.

Organization

The *Third Edition* comprises 25 chapters compartmentalized into six divisions, as depicted in the diagram below.



In recognition of the different levels of mathematical sophistication of the intended audience, we have endeavored to present difficult concepts in two steps: at an introductory level that provides physical insight and motivation, followed by a more advanced analysis. This approach is exemplified by the treatment in Chapter 21 (*Electro-Optics*), in which the subject is first presented using scalar notation and then treated again using tensor notation. Sections dealing with material of a more advanced nature are indicated by asterisks and may be omitted if desired. Summaries are provided at points where recapitulation is deemed useful because of the involved nature of the material.

The form of the book is modular so that it can be used by readers with different needs; this also provides instructors an opportunity to select topics for different courses. Essential material from one chapter is often briefly summarized in another to make each chapter as self-contained as possible. At the beginning of Chapter 25 (*Optical Fiber Communications*), for example, relevant material from earlier chapters describing optical fibers, light sources, optical amplifiers, photodetectors, and photonic integrated circuits is briefly reviewed. This places important information about the components of such systems at the disposal of the reader in advance of presenting system-design and performance considerations.

Contents

A principal feature of the *Third Edition* is a new chapter entitled *Metal and Metamaterial Optics*, an area that has had a substantial and increasing impact on photonics.

The new chapter comprises theory and applications for single- and double-negative media, metal optics, plasmonics, metamaterial optics, and transformation optics.

All chapters have been thoroughly vetted and updated. A chapter-by-chapter compilation of new material in the *Third Edition* is provided below.

- **Chapter 1 (Ray Optics).** Ray-optics descriptions for optical components such as biprisms, axicons, LED light collimators, and Fresnel lenses have been added. The connection between characterizing an arbitrary paraxial optical system by its ray-transfer matrix and its cardinal points has been established. A matrix-optics analysis for imaging with an arbitrary paraxial optical system has been included.
- **Chapter 2 (Wave Optics).** A wave-optics analysis of transmission through biprisms and axicons has been added. A treatment of the Fresnel zone plate from the perspective of interference has been introduced. An analysis of the Michelson–Fabry–Perot (LIGO) interferometer used for the detection of gravitational waves in the distant universe has been incorporated.
- **Chapter 3 (Beam Optics).** An enhanced description of Laguerre–Gaussian beams has been provided. The basic features of several additional optical beams have been introduced: optical vortex, Ince–Gaussian, nondiffracting Bessel, Bessel–Gaussian, and Airy.
- **Chapter 4 (Fourier Optics).** An analysis of Fresnel diffraction from a periodic aperture (Talbot effect) has been included. Nondiffracting waves and Bessel beams have been introduced from a Fourier-optics perspective. A discussion of computer-generated holography has been added.
- **Chapter 5 (Electromagnetic Optics).** A new section on the dipole wave, the basis of near-field optics, has been incorporated. A new section on scattering that includes Rayleigh and Mie scattering, along with attenuation in a medium with scatterers, has been added.
- **Chapter 6 (Polarization Optics).** The material dealing with the dispersion relation in anisotropic media has been reworked to simplify the presentation.
- **Chapter 7 (Photonic-Crystal Optics).** The behavior of the dielectric-slab beam-splitter has been elucidated. A discussion relating to fabrication methods for 3D photonic crystals has been incorporated.
- **Chapter 8 (Metal and Metamaterial Optics).** This new chapter, entitled Metal and Metamaterial Optics, provides a venue for the examination of single- and double-negative media, metal optics, plasmonics, metamaterial optics, and transformation optics. Topics considered include evanescent waves, surface plasmon polaritons, localized surface plasmons, nanoantennas, metasurfaces, subwavelength imaging, and optical cloaking.
- **Chapter 9 (Guided-Wave Optics).** A new section on waveguide arrays that details the mutual coupling of multiple waveguides and introduces the notion of supermodes has been inserted. A new section on plasmonic waveguides that includes metal–insulator–metal and metal-slab waveguides, along with periodic metal–dielectric arrays, has been incorporated.
- **Chapter 10 (Fiber Optics).** A discussion of multicore fibers, fiber couplers, and photonic lanterns has been added. A brief discussion of the applications of photonic-crystal fibers has been provided. A new section on multimaterial fibers, including conventional and hybrid mid-infrared fibers, specialty fibers, multimaterial fibers, and multifunctional fibers, has been introduced.
- **Chapter 11 (Resonator Optics).** A section on plasmonic resonators has been added.
- **Chapter 12 (Statistical Optics).** The sections on optical coherence tomography and unpolarized light have been reorganized.
- **Chapter 13 (Photon Optics).** A brief description of single-photon imaging has been added. The discussion of quadrature-squeezed and photon-number-squeezed

light has been enhanced and examples of the generation and applications of these forms of light have been provided. A section that describes two-photon light, entangled photons, two-photon optics, and the generation and applications thereof, has been incorporated. Examples of two-photon polarization, two-photon spatial optics, and two-beam optics have been appended.

- **Chapter 14 (Light and Matter).** The title of this chapter was changed from *Photons and Atoms* to *Light and Matter*. Brief descriptions of the Zeeman effect, Stark effect, and ionization energies have been added. The discussion of lanthanide-ion manifolds has been enhanced. Descriptions of Doppler cooling, optical molasses, optical tweezers, optical lattices, atom interferometry, and atom amplifiers have been incorporated into the section on laser cooling, laser trapping, and atom optics.
- **Chapter 15 (Laser Amplifiers).** Descriptions of quasi-three-level and in-band pumping have been added. The sections on representative laser amplifiers, including ruby, neodymium-doped glass, erbium-doped silica fiber, and Raman fiber devices, have been enhanced.
- **Chapter 16 (Lasers).** Descriptions of tandem pumping, transition-ion-doped zinc-chalcogenide lasers, silicon Raman lasers, and master-oscillator power-amplifiers (MOPAs) have been added. Descriptions of inner-shell photopumping and X-ray free-electron lasers have been incorporated. A new section on optical frequency combs has been provided.
- **Chapter 17 (Semiconductor Optics).** The section on organic semiconductors has been enhanced. A discussion of group-IV photonics, including graphene and 2D materials such as transition-metal dichalcogenides, has been added. A brief discussion of quantum-dot single-photon emitters has been incorporated.
- **Chapter 18 (LEDs and Laser Diodes).** The title of this chapter was changed from *Semiconductor Photon Sources* to *LEDs and Laser Diodes*. A new section on the essentials of LED lighting has been incorporated. Brief discussions of the following topics are now included: resonant-cavity LEDs, silicon-photonics light sources, quantum-dot semiconductor amplifiers, external-cavity wavelength-tunable laser diodes, broad-area laser diodes, and laser-diode bars and stacks. A discussion of the semiconductor-laser linewidth-enhancement factor has been added. A new section on nanolasers has been introduced.
- **Chapter 19 (Photodetectors).** The title of this chapter was changed from *Semiconductor Photon Detectors* to *Photodetectors*. Brief discussions of the following topics have been added: organic, plasmonic, group-IV-based, and graphene-enhanced photodetectors; edge vs. normal illumination; photon-trapping microstructures; SACM and superlattice APDs; multiplied dark current; and $1/f$ detector noise. New examples include multi-junction photovoltaic solar cells; Ge-on-Si photodiodes; graphene-Si Schottky-barrier photodiodes; and SAM, SACM, and staircase APDs. A new section on single-photon and photon-number-resolving detectors details the operation of SPADs, SiPMs, and TESs.
- **Chapter 20 (Acousto-Optics).** The identical forms of the photoelastic matrix in acousto-optics and the Kerr-effect matrix in electro-optics has been highlighted for cubic isotropic media.
- **Chapter 21 (Electro-Optics).** New sections on passive- and active-matrix liquid-crystal displays have been introduced and their operation has been elucidated. The performance of active-matrix liquid-crystal displays (AMLCDs) has been compared with that of active-matrix organic light-emitting displays (AMOLEDs).
- **Chapter 22 (Nonlinear Optics).** New material relating to guided-wave nonlinear optics has been introduced. Quasi-phase matching in periodically poled integrated optical waveguides, and the associated improvement in wave-mixing efficiency, is now considered. The section pertaining to Raman gain has been enhanced.
- **Chapter 23 (Ultrafast Optics).** New examples have been incorporated that con-

sider chirped pulse amplification in a petawatt laser and the generation of high-energy solitons in a photonic-crystal rod. A new section on high-harmonic generation and attosecond optics has been added. The section on pulse detection has been reorganized.

- **Chapter 24 (Optical Interconnects and Switches).** The role of optical interconnects at the inter-board, inter-chip, and intrachip scale of computer systems is delineated. All-optical switching now incorporates nonparametric and parametric photonic switches that operate on the basis of manifold nonlinear-optical effects. Photonic-crystal and plasmonic photonic switches are discussed. The treatment of photonic logic gates now includes an analysis of embedded bistable systems and examples of bistability in fiber-based-interferometric and microring laser systems.
- **Chapter 25 (Optical Fiber Communications).** The material on fiber-optic components has been updated and rewritten, and the role of photonic integrated circuits is delineated. A new section on space-division multiplexing in multicore and multimode fibers has been added. The section on coherent detection has been expanded and now emphasizes digital coherent receivers with spectrally efficient coding.

Representative Courses

The different chapters of the book may be combined in various ways for use in courses of semester or quarter duration. Representative examples of such courses are presented below. Some of these courses may be offered as part of a sequence. Other selections may be made to suit the particular objectives of instructors and students.

Optics			
1. Ray Optics	8. Metals & Metamaterials	14. Light and Matter	20. Acousto-Optics
2. Wave Optics	9. Guided-Wave Optics	15. Laser Amplifiers	21. Electro-Optics
3. Beam Optics	10. Fiber Optics	16. Lasers	22. Nonlinear Optics
4. Fourier Optics	11. Resonator Optics	17. Semiconductor Optics	23. Ultrafast Optics
5. Electromagnetic Optics	12. Statistical Optics	18. LEDs & Laser Diodes	24. Interconnects/Switches
6. Polarization Optics	13. Photon Optics	19. Photodetectors	25. Fiber Communications
7. Photonic Crystals			

The first six chapters of the book are suitable for an introductory course on *Optics*. These may be supplemented by Chapter 12 (*Statistical Optics*) to introduce incoherent and partially coherent light, and by Chapter 13 (*Photon Optics*) to introduce the photon. The introductory sections of Chapters 9 and 10 (*Guided-Wave Optics* and *Fiber Optics*, respectively) may be added to cover some applications.

Guided-Wave Optics			
1. Ray Optics	8. Metals & Metamaterials	14. Light and Matter	20. Acousto-Optics
2. Wave Optics	9. Guided-Wave Optics	15. Laser Amplifiers	21. Electro-Optics
3. Beam Optics	10. Fiber Optics	16. Lasers	22. Nonlinear Optics
4. Fourier Optics	11. Resonator Optics	17. Semiconductor Optics	23. Ultrafast Optics
5. Electromagnetic Optics	12. Statistical Optics	18. LEDs & Laser Diodes	24. Interconnects/Switches
6. Polarization Optics	13. Photon Optics	19. Photodetectors	25. Fiber Communications
7. Photonic Crystals			

A course on *Guided-Wave Optics* might begin with an introduction to wave propagation in layered and periodic media in Chapter 7 (*Photonic-Crystal Optics*), and could include Chapter 8 (*Metal and Metamaterial Optics*). This would be followed by Chapters 9, 10, and 11 (*Guided-Wave Optics*, *Fiber Optics*, and *Resonator Optics*, respectively). The introductory sections of Chapters 21 and 24 (*Electro-Optics* and *Optical Interconnects and Switches*) would provide additional material.

Lasers

1. Ray Optics	8. Metals & Metamaterials	14. Light and Matter	20. Acousto-Optics
2. Wave Optics	9. Guided-Wave Optics	15. Laser Amplifiers	21. Electro-Optics
3. Beam Optics	10. Fiber Optics	16. Lasers	22. Nonlinear Optics
4. Fourier Optics	11. Resonator Optics	17. Semiconductor Optics	23. Ultrafast Optics
5. Electromagnetic Optics	12. Statistical Optics	18. LEDs & Laser Diodes	24. Interconnects/Switches
6. Polarization Optics	13. Photon Optics	19. Photodetectors	25. Fiber Communications
7. Photonic Crystals			

A course on *Lasers* could begin with *Beam Optics* and *Resonator Optics* (Chapters 3 and 11, respectively), followed by *Light and Matter* (Chapter 14). The initial portion of *Photon Optics* (Chapter 13) could be assigned. The heart of the course would be the material contained in *Laser Amplifiers* and *Lasers* (Chapters 15 and 16, respectively). The course might also include material drawn from *Semiconductor Optics* and *LEDs and Laser Diodes* (Chapters 17 and 18, respectively). An introduction to femtosecond lasers could be extracted from some sections of *Ultrafast Optics* (Chapter 23).

Optoelectronics

1. Ray Optics	8. Metals & Metamaterials	14. Light and Matter	20. Acousto-Optics
2. Wave Optics	9. Guided-Wave Optics	15. Laser Amplifiers	21. Electro-Optics
3. Beam Optics	10. Fiber Optics	16. Lasers	22. Nonlinear Optics
4. Fourier Optics	11. Resonator Optics	17. Semiconductor Optics	23. Ultrafast Optics
5. Electromagnetic Optics	12. Statistical Optics	18. LEDs & Laser Diodes	24. Interconnects/Switches
6. Polarization Optics	13. Photon Optics	19. Photodetectors	25. Fiber Communications
7. Photonic Crystals			

The chapters on *Semiconductor Optics*, *LEDs and Laser Diodes*, and *Photodetectors* (Chapters 17, 18, and 19, respectively) form a suitable basis for a course on *Optoelectronics*. This material would be supplemented with optics background from earlier chapters and could include topics such as liquid-crystal devices (Secs. 6.5 and 21.3), electroabsorption modulators (Sec. 21.5), and an introduction to photonic devices used for switching and/or communications (Chapters 24 and 25, respectively).

Photonic Devices

1. Ray Optics	8. Metals & Metamaterials	14. Light and Matter	20. Acousto-Optics
2. Wave Optics	9. Guided-Wave Optics	15. Laser Amplifiers	21. Electro-Optics
3. Beam Optics	10. Fiber Optics	16. Lasers	22. Nonlinear Optics
4. Fourier Optics	11. Resonator Optics	17. Semiconductor Optics	23. Ultrafast Optics
5. Electromagnetic Optics	12. Statistical Optics	18. LEDs & Laser Diodes	24. Interconnects/Switches
6. Polarization Optics	13. Photon Optics	19. Photodetectors	25. Fiber Communications
7. Photonic Crystals			

Photonic Devices is a course that would consider the devices used in *Acousto-Optics*, *Electro-Optics*, and *Nonlinear Optics* (Chapters 20, 21, and 22, respectively). It might also include devices used in optical routing and switching, as discussed in *Optical Interconnects and Switches* (Chapter 24).

Nonlinear & Ultrafast Optics

1. Ray Optics	8. Metals & Metamaterials	14. Light and Matter	20. Acousto-Optics
2. Wave Optics	9. Guided-Wave Optics	15. Laser Amplifiers	21. Electro-Optics
3. Beam Optics	10. Fiber Optics	16. Lasers	22. Nonlinear Optics
4. Fourier Optics	11. Resonator Optics	17. Semiconductor Optics	23. Ultrafast Optics
5. Electromagnetic Optics	12. Statistical Optics	18. LEDs & Laser Diodes	24. Interconnects/Switches
6. Polarization Optics	13. Photon Optics	19. Photodetectors	25. Fiber Communications
7. Photonic Crystals			

The material contained in Chapters 21–23 (*Electro-Optics*, *Nonlinear Optics*, and *Ultrafast Optics*, respectively) is suitable for an in-depth course on *Nonlinear and Ultrafast Optics*. These chapters

could be supplemented by the material pertaining to electro-optic and all-optical switching in Chapter 24 (*Optical Interconnects and Switches*).

Fiber-Optic Communications					
1. Ray Optics	8. Metals & Metamaterials	14. Light and Matter	20. Acousto-Optics		
2. Wave Optics	9. Guided-Wave Optics	15. Laser Amplifiers	21. Electro-Optics		
3. Beam Optics	10. Fiber Optics	16. Lasers	22. Nonlinear Optics		
4. Fourier Optics	11. Resonator Optics	17. Semiconductor Optics	23. Ultrafast Optics		
5. Electromagnetic Optics	12. Statistical Optics	18. LEDs & Laser Diodes	24. Interconnects/Switches		
6. Polarization Optics	13. Photon Optics	19. Photodetectors	25. Fiber Communications		
7. Photonic Crystals					

The heart of a course on *Fiber-Optic Communications* would be the material contained in Chapter 25 (*Optical Fiber Communications*). Background for this course would comprise material drawn from Chapters 9, 10, 18, and 19 (*Guided-Wave Optics*, *Fiber Optics*, *LEDs and Laser Diodes*, and *Photodetectors*, respectively), along with material contained in Secs. 15.3C and 15.3D (doped-fiber and Raman fiber amplifiers, respectively). If fiber-optic networks were to be emphasized, Sec. 24.3 (photonic switches) would be a valuable adjunct.

Optical Information Processing					
1. Ray Optics	8. Metals & Metamaterials	14. Light and Matter	20. Acousto-Optics		
2. Wave Optics	9. Guided-Wave Optics	15. Laser Amplifiers	21. Electro-Optics		
3. Beam Optics	10. Fiber Optics	16. Lasers	22. Nonlinear Optics		
4. Fourier Optics	11. Resonator Optics	17. Semiconductor Optics	23. Ultrafast Optics		
5. Electromagnetic Optics	12. Statistical Optics	18. LEDs & Laser Diodes	24. Interconnects/Switches		
6. Polarization Optics	13. Photon Optics	19. Photodetectors	25. Fiber Communications		
7. Photonic Crystals					

Background material for a course on *Optical Information Processing* would be drawn from *Wave Optics* and *Beam Optics* (Chapters 2 and 3, respectively). The course could cover coherent image formation and processing from *Fourier Optics* (Chapter 4) along with incoherent and partially coherent imaging from *Statistical Optics* (Chapter 12). The focus could then shift to devices used for analog data processing, such as those considered in *Acousto-Optics* (Chapter 20). The course could then finish with material on switches and gates used for digital data processing, such as those considered in *Optical Interconnects and Switches* (Chapter 24).

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BAHAA E. A. SALEH

Orlando, Florida

MALVIN CARL TEICH

Boston, Massachusetts

June 4, 2018

PREFACE TO THE SECOND EDITION

Since the publication of the *First Edition* in 1991, *Fundamentals of Photonics* has been reprinted some 20 times, translated into Czech and Japanese, and used worldwide as a textbook and reference. During this period, major developments in photonics have continued apace, and have enabled technologies such as telecommunications and applications in industry and medicine. The *Second Edition* reports some of these developments, while maintaining the size of this single-volume tome within practical limits.

In its new organization, *Fundamentals of Photonics* continues to serve as a self-contained and up-to-date introductory-level textbook, featuring a logical blend of theory and applications. Many readers of the *First Edition* have been pleased with its abundant and well-illustrated figures. This feature has been enhanced in the *Second Edition* by the introduction of full color throughout the book, offering improved clarity and readability.

While each of the 22 chapters of the *First Edition* has been thoroughly updated, the principal feature of the *Second Edition* is the addition of two new chapters: one on photonic-crystal optics and another on ultrafast optics. These deal with developments that have had a substantial and growing impact on photonics over the past decade.

The new chapter on **photonic-crystal optics** provides a foundation for understanding the optics of layered media, including Bragg gratings, with the help of a matrix approach. Propagation of light in one-dimensional periodic media is examined using Bloch modes with matrix and Fourier methods. The concept of the photonic bandgap is introduced. Light propagation in two- and three-dimensional photonic crystals, and the associated dispersion relations and bandgap structures, are developed. Sections on photonic-crystal waveguides, holey fibers, and photonic-crystal resonators have also been added at appropriate locations in other chapters.

The new chapter on **ultrafast optics** contains sections on picosecond and femtosecond optical pulses and their characterization, shaping, and compression, as well as their propagation in optical fibers, in the domain of linear optics. Sections on ultrafast nonlinear optics include pulsed parametric interactions and optical solitons. Methods for the detection of ultrafast optical pulses using available detectors, which are relatively slow, are reviewed.

In addition to these two new chapters, the chapter on **optical interconnects and switches** has been completely rewritten and supplemented with topics such as wavelength and time routing and switching, FBGs, WGRs, SOAs, TOADs, and packet switches. The chapter on **optical fiber communications** has also been significantly updated and supplemented with material on WDM networks; it now offers concise descriptions of topics such as dispersion compensation and management, optical amplifiers, and soliton optical communications.

Continuing advances in device-fabrication technology have stimulated the emergence of **nanophotonics**, which deals with optical processes that take place over subwavelength (nanometer) spatial scales. Nanophotonic devices and systems include quantum-confined structures, such as quantum dots, nanoparticles, and nanoscale periodic structures used to synthesize *metamaterials* with exotic optical properties such as negative refractive index. They also include configurations in which light (or its interaction with matter) is confined to nanometer-size (rather than micrometer-size) regions near boundaries, as in *surface plasmon* optics. Evanescent fields, such as those produced at a surface where total internal reflection occurs, also exhibit such

confinement. Evanescent fields are present in the immediate vicinity of subwavelength-size apertures, such as the open tip of a tapered optical fiber. Their use allows imaging with resolution beyond the diffraction limit and forms the basis of *near-field optics*. Many of these emerging areas are described at suitable locations in the *Second Edition*.

New sections have been added in the process of updating the various chapters. New topics introduced in the early chapters include: Laguerre–Gaussian beams; near-field imaging; the Sellmeier equation; fast and slow light; optics of conductive media and plasmonics; doubly negative metamaterials; the Poincaré sphere and Stokes parameters; polarization mode dispersion; whispering-gallery modes; microresonators; optical coherence tomography; and photon orbital angular momentum.

In the chapters on laser optics, new topics include: rare-earth and Raman fiber amplifiers and lasers; EUV, X-ray, and free-electron lasers; and chemical and random lasers. In the area of optoelectronics, new topics include: gallium nitride-based structures and devices; superluminescent diodes; organic and white-light LEDs; quantum-confined lasers; quantum cascade lasers; microcavity lasers; photonic-crystal lasers; array detectors; low-noise APDs; SPADs; and QWIPs.

The chapter on nonlinear optics has been supplemented with material on parametric-interaction tuning curves; quasi-phase-matching devices; two-wave mixing and cross-phase modulation; THz generation; and other nonlinear optical phenomena associated with narrow optical pulses, including chirp pulse amplification and supercontinuum light generation. The chapter on electro-optics now includes a discussion of electroabsorption modulators.

Appendix C on **modes of linear systems** has been expanded and now offers an overview of the concept of modes as they appear in numerous locations within the book. Finally, additional exercises and problems have been provided, and these are now numbered disjointly to avoid confusion.

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We are indebted to the legions of students and postdoctoral associates who have posed so many excellent questions that helped us hone our presentation. In particular, many improvements were initiated by suggestions from Mark Booth, Jasper Cabalu, Michael Cunha, Darryl Goode, Chris LaFratta, Rui Li, Eric Lynch, Nan Ma, Nishant Mohan, Julie Praino, Yunjie Tong, and Ranjith Zachariah. We are especially grateful to Mohammed Saleh, who diligently read much of the manuscript and provided us with excellent suggestions for improvement throughout.

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BAHAA E. A. SALEH

MALVIN CARL TEICH

*Boston, Massachusetts
December 19, 2006*

PREFACE TO THE FIRST EDITION

Optics is an old and venerable subject involving the generation, propagation, and detection of light. Three major developments, which have been achieved in the last thirty years, are responsible for the rejuvenation of optics and for its increasing importance in modern technology: the invention of the laser, the fabrication of low-loss optical fibers, and the introduction of semiconductor optical devices. As a result of these developments, new disciplines have emerged and new terms describing these disciplines have come into use: **electro-optics**, **optoelectronics**, **quantum electronics**, **quantum optics**, and **lightwave technology**. Although there is a lack of complete agreement about the precise usages of these terms, there is a general consensus regarding their meanings.

Photonics

Electro-optics is generally reserved for optical devices in which electrical effects play a role (lasers, and electro-optic modulators and switches, for example). *Optoelectronics*, on the other hand, typically refers to devices and systems that are essentially electronic in nature but involve light (examples are light-emitting diodes, liquid-crystal display devices, and array photodetectors). The term *quantum electronics* is used in connection with devices and systems that rely principally on the interaction of light with matter (lasers and nonlinear optical devices used for optical amplification and wave mixing serve as examples). Studies of the quantum and coherence properties of light lie within the realm of *quantum optics*. The term *lightwave technology* has been used to describe devices and systems that are used in optical communications and optical signal processing.

In recent years, the term **photonics** has come into use. This term, which was coined in analogy with electronics, reflects the growing tie between optics and electronics forged by the increasing role that semiconductor materials and devices play in optical systems. *Electronics* involves the control of electric-charge flow (in vacuum or in matter); *photonics* involves the control of photons (in free space or in matter). The two disciplines clearly overlap since electrons often control the flow of photons and, conversely, photons control the flow of electrons. The term *photonics* also reflects the importance of the photon nature of light in describing the operation of many optical devices.

Scope

This book provides an introduction to the fundamentals of photonics. The term *photonics* is used broadly to encompass all of the aforementioned areas, including the following:

- The *generation* of coherent light by lasers, and incoherent light by luminescence sources such as light-emitting diodes.
- The *transmission* of light in free space, through conventional optical components such as lenses, apertures, and imaging systems, and through waveguides such as optical fibers.
- The *modulation*, switching, and scanning of light by the use of electrically, acoustically, or optically controlled devices.
- The *amplification* and *frequency conversion* of light by the use of wave interactions in nonlinear materials.
- The *detection* of light.

These areas have found ever-increasing applications in optical communications, signal processing, computing, sensing, display, printing, and energy transport.

Approach and Presentation

The underpinnings of photonics are provided in a number of chapters that offer concise introductions to:

- The four theories of light (each successively more advanced than the preceding): ray optics, wave optics, electromagnetic optics, and photon optics.
- The theory of interaction of light with matter.
- The theory of semiconductor materials and their optical properties.

These chapters serve as basic building blocks that are used in other chapters to describe the *generation* of light (by lasers and light-emitting diodes); the *transmission* of light (by optical beams, diffraction, imaging, optical waveguides, and optical fibers); the *modulation* and switching of light (by the use of electro-optic, acousto-optic, and nonlinear-optic devices); and the *detection* of light (by means of photodetectors). Many applications and examples of real systems are provided so that the book is a blend theory and practice. The final chapter is devoted to the study of fiber-optic communications, which provides an especially rich example in which the generation, transmission, modulation, and detection of light are all part of a single photonic system used for the transmission of information.

The theories of light are presented at progressively increasing levels of difficulty. Thus light is described first as rays, then scalar waves, then electromagnetic waves, and finally, photons. Each of these descriptions has its domain of applicability. Our approach is to draw from the simplest theory that adequately describes the phenomenon or intended application. Ray optics is therefore used to describe imaging systems and the confinement of light in waveguides and optical resonators. Scalar wave theory provides a description of optical beams, which are essential for the understanding of lasers, and of Fourier optics, which is useful for describing coherent optical systems and holography. Electromagnetic theory provides the basis for the polarization and dispersion of light, and the optics of guided waves, fibers, and resonators. Photon optics serves to describe the interactions of light with matter, explaining such processes as light generation and detection, and light mixing in nonlinear media.

Intended Audience

Fundamentals of Photonics is meant to serve as:

- An introductory textbook for students in electrical engineering or applied physics at the senior or first-year graduate level.
- A self-contained work for self-study.
- A text for programs of continuing professional development offered by industry, universities, and professional societies.

The reader is assumed to have a background in engineering or applied physics, including courses in modern physics, electricity and magnetism, and wave motion. Some knowledge of linear systems and elementary quantum mechanics is helpful but not essential. Our intent has been to provide an introduction to photonics that emphasizes the concepts governing applications of current interest. The book should, therefore, not be considered as a compendium that encompasses all photonic devices and systems. Indeed, some areas of photonics are not included at all, and many of the individual chapters could easily have been expanded into separate monographs.

Problems, Reading Lists, and Appendices

A set of problems is provided at the end of each chapter. Problems are numbered in accordance with the chapter sections to which they apply. Quite often, problems deal with ideas or applications not mentioned in the text, analytical derivations, and numerical computations designed to illustrate the magnitudes of important quantities. Problems marked with asterisks are of a more advanced nature. A number of exercises also appear within the text of each chapter to help the reader develop a better understanding of (or to introduce an extension of) the material.

Appendices summarize the properties of one- and two-dimensional Fourier transforms, linear-systems theory, and modes of linear systems (which are important in polarization devices, optical waveguides, and resonators); these are called upon at appropriate points throughout the book. Each chapter ends with a reading list that includes a selection of important books, review articles, and a few classic papers of special significance.

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Madison, Wisconsin

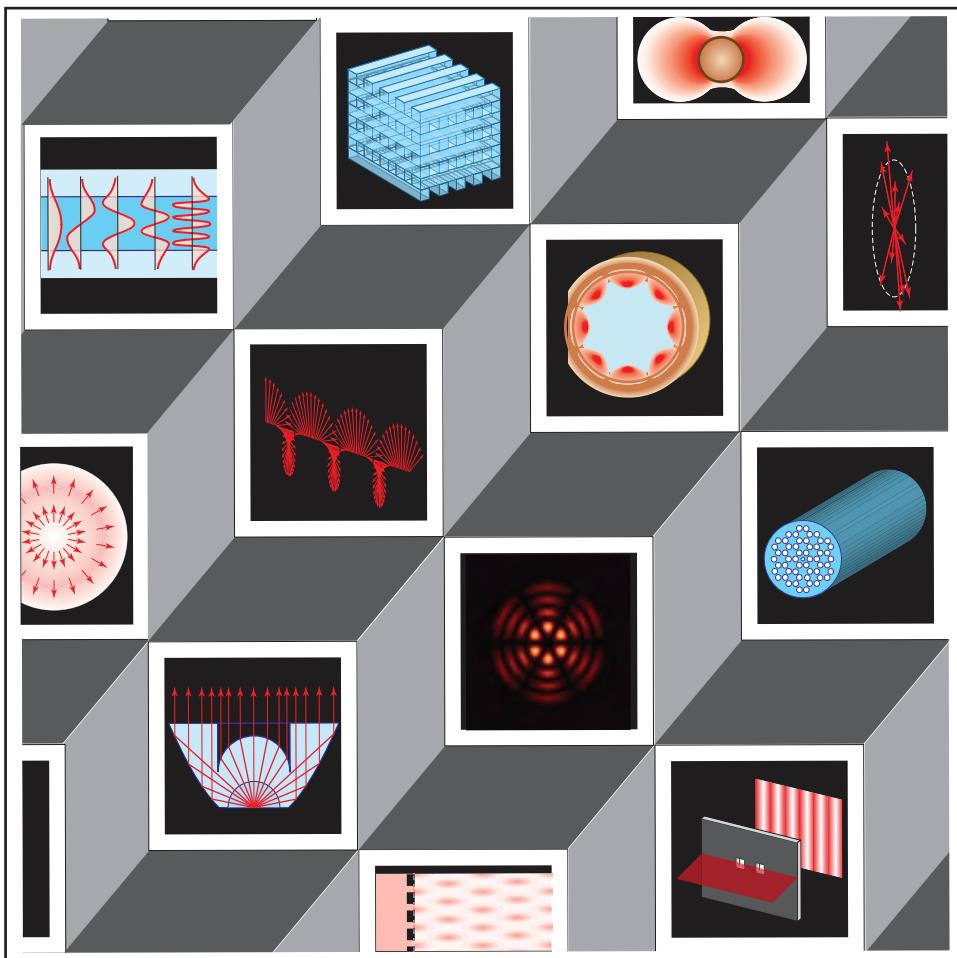
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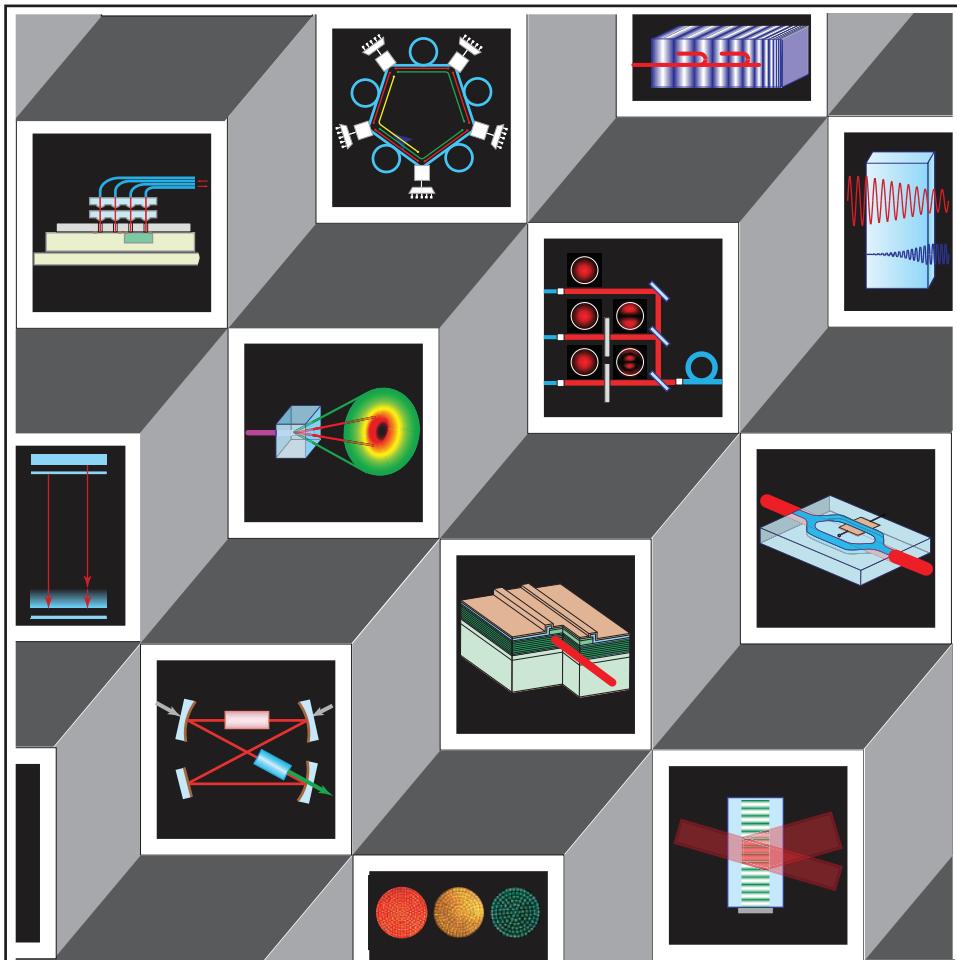
FUNDAMENTALS OF PHOTONICS

Part I: Optics (Chapters 1–13)



FUNDAMENTALS OF PHOTONICS

Part II: Photonics (Chapters 14–25)



AUTHORS



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His research contributions cover a broad spectrum of topics in optics and photonics including statistical optics, nonlinear optics, quantum optics, and image science. He is the author of *Photoelectron Statistics* (Springer-Verlag, 1978) and the co-author of *Fundamentals of Photonics* (Wiley, *First Edition* 1991, *Second Edition* 2007, *Third Edition* 2019) and *Introduction to Subsurface Imaging* (Cambridge University Press, 2011). He has published more than 600 papers in technical journals and conference proceedings. He holds nine patents.

Saleh served as the founding editor of the OSA journal *Advances in Optics and Photonics* (2008–2013), editor-in-chief of the *Journal of the Optical Society of America A* (1991–1997), and Chairman of the Board of Editors of OSA (1997–2001). He served as Vice President of the International Commission of Optics (ICO) (2000–2002), and as a member of the Board of Directors of the Laser Institute of America (2010–2011). He is a Fellow of the Institute of Electrical and Electronics Engineers (IEEE), the Optical Society of America (OSA), the International Society for Optics and Photonics (SPIE), the American Physical Society (APS), and the Guggenheim Foundation. He received the 1999 OSA Beller Medal for outstanding contributions to optical science and engineering education, the 2004 SPIE BACUS award for his contribution to photomask technology, the 2006 Kuwait Prize, the 2008 OSA Distinguished Service Award, and the 2013 OSA Mees Medal. He is a member of Phi Beta Kappa, Sigma Xi, and Tau Beta Pi.



Malvin Carl Teich received the S.B. degree in physics from the Massachusetts Institute of Technology in 1961, the M.S. degree in electrical engineering from Stanford University in 1962, and the Ph.D. degree from Cornell University in 1966. His first professional affiliation, in 1966, was with MIT Lincoln Laboratory. He joined the faculty at Columbia University in 1967, where he served as a member of the Electrical Engineering Department (as Chairman from 1978 to 1980), the Applied Physics and Applied Mathematics Department, the Columbia Radiation Laboratory in the Department of Physics, and the Fowler Memorial Laboratory at the Columbia College of Physicians

& Surgeons. During his tenure at Columbia, he carried out research in the areas of photon statistics and point processes; quantum heterodyne detection; the generation of nonclassical light; noise in avalanche photodiodes and fiber-optic amplifiers; and information transmission in biological sensory systems. In 1996 he became Professor Emeritus at Columbia.

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INDEX

- k** surface
anisotropic medium, 234–237
- ABCD**
inverse ray-transfer matrix, 31
law, 97–99
ray-transfer matrix, 28, 1302
transmission matrix, 380
wave-transfer matrix, 259, 1303
- g*-parameters, 448
- q*-parameter, 81, 97
- Absorption
and scattering, 198–199
atoms, 584, 589–593
coefficient, 182, 198, 777
coefficient in resonant medium, 189
cross section, 199
dielectric media, 181–184
efficiency, 199
indirect-bandgap semiconductor, 771
left-handed media, 309
occupancy probability, 773
semiconductors, 769
strong, 184
transition rate, 592, 775
weak, 183
- Acceptance angle, 19, 25, 395
- Acousto-optic devices, 958–967
acoustic spectrum analyzer, 963
figure of merit, 973
filter, 966
frequency shifter, 967
intensity modulator, 959, 973
intensity reflectance, 973
interconnection capacity, 966
optical isolator, 967
reflector, 973
scanner, 961
spatial light modulator, 965
switch, photonic, 959, 964, 1194
- Acousto-optics, 943–974
anisotropic media, 967–971
Born approximation, 953, 973
- Bragg angle, 948
Bragg condition, 948
Bragg condition tolerance, 949
Bragg diffraction, 945–958, 972, 973
Bragg diffraction by beam, 956, 961
Bragg diffraction by thin beam, 957
Bragg diffraction, downshifted, 952
Bragg diffraction, upshifted, 949
coupled-wave equations, 953, 954
Debye–Sears scattering, 957, 973
Doppler shift, 950
elasto-optic coefficient, 946
figure of merit, 946
index-ellipsoid modification, 970
introduction to, 944–945
Raman–Nath scattering, 973
reflectance, amplitude, 948
reflectance, intensity, 950
scattering theory, 953, 973
strain-optic coefficient, 946
- Airy
beam, 106–107
beam generation, 107, 158
disk, 131
formulas, 261
function, 107
pattern, 131
- Amplified spontaneous emission (ASE), 651–653, 699, 821, 830
- Amplifier
Brillouin fiber, 644
chirped pulse, 1095
electronic, 620, 621
laser, 619–656, 659
phase, 70
phase-sensitive, 1062
Raman fiber, 642–644
reflection, 1065
semiconductor, 817–831
transmission, 1065
- Anharmonic oscillator, 1071–1073
- Anisotropic media
k surface, 234–237

- acousto-optics of, 967–971
arbitrary propagation, 232–233
biaxial crystal, 229
conductive, 882
dispersion relation, 234–237
double refraction, 238–239, 254
electro-optics of, 989–996
ellipsoid of revolution, 318
energy transport, 234–237
extraordinary refractive index, 229
four-wave mixing, 1074
gyration vector, 241
hyperbolic, 339–340, 352
hyperboloid of revolution, 318
impermeability tensor, 230
index ellipsoid, 230, 232–233
liquid crystals, 244–246, 996–1005
magneto-optics, 242–243
magnetogyration coefficient, 243
mixed-sign permittivities, 317, 352
negative uniaxial crystal, 229
negative-index, 338–339
nonlinear and dispersive, 1073
nonlinear optics of, 1066–1069
normal modes, 230, 232–233, 241
normal surface, 234–237
optic axis, 229
optical activity, 240–242
optics of, 227–239
ordinary refractive index, 229
permittivity tensor, 228
photoelastic effect, 968
positive uniaxial crystal, 229
principal axes, 229
principal refractive indices, 229
principal-axis propagation, 230–231
quadric representation, 229, 230, 317
rays, 234–237
refraction of rays, 239, 254
refractive indices of, 228–230
three-wave mixing, 1066–1069, 1073
uniaxial crystal, 229, 233, 236, 317
Verdet constant, 243
wavefronts, 234–237
- Antenna
optical, 332–334
plasmonic, 332–334
- Antibunching, photon, 780
- Antireflection coating, 264, 301
- Aperture
function, 129, 138
ring, 67, 118, 159
- Approximation
Born, 192, 953, 973, 1020, 1076
- Fraunhofer, 124, 125, 130
Fresnel, 49, 121, 125, 130
paraboloidal, 49
paraxial, 9, 50
quasi-static, 196, 197
quasi-stationary, 944
SVE, 51, 563, 954, 1050, 1064, 1086, 1111, 1127, 1133
Taylor-series, 10, 203, 1127
Volterra-series, 1070
WKB, 407
- Array detectors, *see* Photodetectors
- Atoms
absorption, 584, 589–593
atom amplifier, 602
atom chip, 602
atom interferometry, 601
atom optics, 601
atomic number, 564, 568
Bose–Einstein condensate, 601
bosonic, 568, 602
Doppler cooling, 599
electron configuration, 565, 566, 569
energy levels, 562
evaporative cooling, 600
fermionic, 568
Hartree method, 565
hydrogen, 564
interaction with broadband light, 590
interaction with light, 583–602
ionization energy, 568
isotopes, 568
laser cooling, 599
laser trapping, 600
lineshape function, 586
magnetic trap, 602
magneto-optical trap, 601
matter waves, 601
mononuclidic, 568
multielectron, 565–568
optical lattices, 601
optical molasses, 599
optical tweezers, 600
Pauli exclusion principle, 565
periodic table, 566, 567
photon recoil, 524, 555, 600
polarization gradient cooling, 600
relative atomic mass, 568
shells and subshells, 565
Sisyphus cooling, 600
spontaneous emission, 583, 587–588
spontaneous lifetime, 587, 588
spontaneous lifetime, effective, 589
stimulated emission, 585, 589–593

- term symbol, 566, 569
- transition strength, 586
- Attenuation
 - and scattering, 198, 416, 432
 - coefficient, 182, 415–417
 - optical fiber, 415–417
- Attosecond optics, 1141–1145
- Auger recombination, 752, 821
- Autocorrelation, 1288
- Avalanche photodiodes, 895–907
 - avalanche buildup time, 899
 - breakdown voltage, 901
 - comparison with photodiodes, 927
 - conventional (CAPD), 895
 - dead space, 903
 - excess noise factor, 917–921
 - gain, 896, 898, 940
 - gain noise, 917–921
 - Geiger-mode, 904
 - group-IV, 902
 - initial-energy effects, 903
 - ionization coefficients, 895
 - ionization ratio, 896
 - materials, 901
 - position-dependent gradients, 904
 - position-dependent ionization, 904
 - punchthrough voltage, 901
 - reach-through device, 899
 - response time, 899
 - responsivity, 898
 - SACM device, 899, 902
 - SAM device, 899, 901, 902
 - SCIDCM devices, 897, 917
 - SCISCM devices, 896
 - sick space, 903
 - single-photon (SPAD), 904
- Axicon, 14, 57, 106, 137
- Band-structure engineering, 851
- Bandgap
 - direct, 737
 - energy, 576, 733, 738
 - indirect, 737
 - wavelength, 738, 768
- Bardeen, John, 731
- Basov, Nikolai G., 619
- Beam, optical, 79–109
 - accelerating, 107
 - Airy, 106–107, 158
 - Bessel, 57, 105, 136, 137
 - Bessel–Gaussian, 106, 181
 - Bessel/Gaussian comparison, 106
 - divergence–size tradeoff, 85, 106
 - donut, 103, 109
 - elliptic Gaussian, 102, 109
 - elliptic Hermite–Gaussian, 102
 - Gaussian, 51, 80–99
 - Hermite–Gaussian, 99–102, 105
 - holographic generation, 155
 - Ince–Gaussian, 105
 - introduction to, 80
 - Laguerre–Gaussian, 102–105, 155
 - nondiffracting, 57, 105, 136, 137
 - quality, 90
 - self-healing, 107
 - toroidal, 103, 109
 - vector, 179, 180
 - vortex, 104
- Beamsplitter, 13, 63, 301, 549
 - dielectric-slab, 268
 - phase shift, 64, 269
 - polarizing, 239, 247
 - random partitioning, 539, 555
 - scattering matrix, 263
 - single-photon transmittance, 522
 - two-photon transmittance, 550
 - wave-transfer matrix, 263
- Bell Laboratories, 1163
- Bessel
 - Gaussian beam, 106
 - beam, 57, 105, 136, 137
 - beam vs. Gaussian beam, 106
 - function, 105, 131, 398, 467, 1295
- Bessel, Friedrich Wilhelm, 79
- Bioluminescence, 608
- Biprism, 14, 57
 - Fresnel, 14, 57
- Bistability, optical
 - amplifying NL element, 1218, 1219
 - coupled microring lasers, 1219
 - devices, 1216–1220
 - dispersive NL element, 1216, 1220
 - dissipative NL element, 1217
 - embedded system, 1215
 - Fabry–Perot, nonlinear, 1217, 1218
 - hybrid, 1220
 - hysteresis, 1211
 - intrinsic system, 1215
 - MZI, nonlinear, 1216, 1218
 - photonic logic, 1223
 - principles of, 1213–1215
 - quantum-confined Stark effect, 1220
 - saturable absorber, 1217
 - self-electro-optic-effect device, 1220
 - spatial light modulator, 1220
 - systems, 1211
- Blackbody radiation, 602–607
 - 1D, 618, 923

- 2D, 617
- spectrum, 604
- correlated color temperature, 812
- emission comparison, 617
- Rayleigh–Jeans formula, 463, 606
- Stefan–Boltzmann law, 606, 618
- thermal equilibrium, 602
- thermal light, 602
- thermography, 606
- Wien’s law, 617
- Bloch
 - modes, 257, 277–282, 295, 734, 1305
 - phase, 281
 - wavenumber, 278
- Bloch, Felix, 255
- Bloembergen, Nicolaas, 1015
- Bohr
 - atom, 564
 - period, 564, 705
 - radius, 564, 784
- Bohr, Niels, 561
- Boltzmann distribution, 536, 581
- Bonding
 - covalent, 573, 576, 743
 - ionic, 573, 576
 - metallic, 576
 - van der Waals, 573, 576, 743
- Born approximation
 - for acousto-optics, 953, 973
 - for nonlinear optics, 1020
 - for scattering, 192–193
- Born postulate, 563
- Born, Max, 473
- Bose–Einstein
 - condensate, 601, 602
 - distribution, 536
- Boson, 524, 537, 568
- Boundary
 - conditions, 164, 221
 - planar, 11
 - spherical, 14
- Bragg
 - angle, 67, 270, 948
 - condition, 270, 948
 - condition, tolerance, 949
 - diffraction, 945–958, 972, 973
 - diffraction by acoustic beam, 956, 961
 - diffraction of optical beam, 955
 - diffraction, quantum view, 952
 - diffraction, Raman–Nath, 957
 - frequency, 270
 - reflection, 67
- Bragg grating, 269–276, 698
- chirp filter, 1099, 1161
- distributed Bragg reflector, 269, 434, 466, 471, 798
- fiber, 269, 687, 692
- total reflection, 273
- waveguide, 385
- Bragg, William Henry, 943
- Bragg, William Lawrence, 943
- Brattain, Walter H., 731
- Bremsstrahlung, 562
- Brewster
 - angle, 224, 225, 247, 253
 - window, 225
- Brillouin
 - fiber amplifier, 644
 - scattering, 613
 - zone, 278, 279, 283, 735, 738
 - zone, irreducible, 295
- Bulk optics, 305, 354
- Catadioptric system, 15
- Cathodoluminescence, 607, 608, 618
- Caustic
 - curve, 9, 17
 - surface, 397
- Characteristic equation
 - optical fiber, 400
- Chemiluminescence, 608
- Cherenkov radiation, 562, 875
- Chirp
 - coefficient, 1090
 - coefficient, angular-dispersion, 1097
 - coefficient, Bragg-grating, 1099
 - function, 1289
 - parameter, 1082
 - pulse amplifier, 1095
- Chirp filter, 1088–1099
 - angular-dispersion, 1096
 - arbitrary phase filter, 1090
 - Bragg-grating, 1099, 1161
 - cascaded, 1090
 - chirp coefficient, 1090
 - diffraction-grating, 1098
 - envelope transfer function, 1088
 - for compression, 1094
 - for expansion, 1094
 - ideal filter, 1089
 - implementations of, 1095–1099
 - impulse response function, 1090
 - optical-fiber, 1103–1111, 1161
 - phase filter, 1089
 - prism, 1097, 1105, 1161
 - vs. quadratic-phase modulator, 1100
- Circular

- dichroism, 254
- polarization, 213, 253, 524
- Circulator, optical, 251, 1168, 1173
- CMOS technology, 375, 907, 909
 - scientific CMOS (sCMOS), 909
- Coherence
 - area, 485, 495
 - coherent light, 62, 152, 474, 544
 - cross-spectral density, 486
 - cross-spectral purity, 486
 - degree of coherence, 483
 - degree of temporal coherence, 478
 - distance, 495, 505
 - enhancement via filtering, 481, 489
 - extended radiator, 485
 - gain via propagation, 502
 - incoherent light, 485
 - introduction to, 474–475
 - length, 479
 - length, wave-mixing, 1032
 - longitudinal, 487
 - mutual coherence function, 483
 - mutual intensity, 485, 498, 502, 549
 - partial polarization, 506–510
 - power spectral density, 479
 - quantum, 483
 - quasi-monochromatic light, 485
 - random wavepacket sequence, 482
 - role in interference, 489–496
 - role in interferometry, 490, 493
 - spatial, 483–487
 - speckle, 406
 - spectral density, 479
 - spectral width, 481
 - temporal, 476–483
 - temporal coherence function, 477
 - time, 478
 - transmission, 497
 - van Cittert–Zernike theorem, 503
 - Wiener–Khinchin theorem, 480
 - Wolf equations, 484
- Coherent
 - anti-Stokes Raman scattering, 614
 - detection, 74, 1266
 - lidar, 75
 - optical amplifier, 620
- Colladon, Jean-Daniel, 353
- Collimator, 9, 15
- Color-rendering index, 812, 816
- Comb, optical frequency, 721, 1141
 - applications, 722
- Complex
 - amplitude, 46, 80
 - analytic signal, 71
- degree of coherence, 483
- degree of temporal coherence, 478
- envelope, 47, 73, 80, 175, 211, 1080
- representation, 45
- wavefunction, 45, 72
- Conductive medium, 320–326
 - power reflectance, 321
- Conductivity, 320, 882
 - tensor, 882
- Constitutive relation, 166
- Converter
 - evanescent-to-propagating, 317
 - frequency, 548, 610, 611, 1027, 1054
 - incoherent-to-coherent, 989, 1005
 - indistinguishable-to-entangled, 550
 - mode, 789, 1265
 - space-to-time, 1119
 - wavelength, 1205
- Convolution, 1288, 1294, 1296, 1300
- Corkum, Paul B., 1078
- Correlation, 1288
- Coupled-wave theory
 - acousto-optics, 953, 954
 - four-wave mixing, 1059
 - three-wave mixing, 1047, 1127
 - waveguide, 378
- Coupler
 - prism, 329
- Critical angle, 12, 223, 225, 310, 327
 - complementary, 363
- Cross section
 - absorption, 199
 - effective absorption, 585, 634
 - effective emission, 585, 634
 - Füchtbauer–Ladenburg equation, 588
 - lineshape function, 586
 - scattering, 195, 196
 - transition, 584, 588, 634, 644
 - transition strength, 586
- Cross-phase modulation, 1041, 1197
- Crystal
 - biaxial, 229
 - negative uniaxial, 229
 - positive uniaxial, 229
 - structure, 294
 - symmetry, 991
 - uniaxial, 229
- Cutoff frequency
 - waveguide, 359, 366
- Debye–Sears scattering, 973
- Degeneracy parameter, 582
- Delay, group, 200
- Detectors, *see* Photodetectors

- Dichroism, 247
 - circular, 254
- Dielectric
 - boundary, reflection from, 53
 - boundary, refraction at, 53
 - constant, 167
- Diffraction, 129–136
 - aperture function, 129
 - Bragg, 945–958
 - circular aperture, 131
 - dispersion analogy, 1112
 - focused optical beam, 132
 - Fraunhofer, 130–132, 158
 - Fresnel, 132–137, 158
 - Gaussian aperture, 134
 - grating, 59, 78, 158
 - nondiffracting beams, 105–107
 - nondiffracting waves, 136
 - periodic aperture, 135
 - rectangular aperture, 130
 - single-photon, 523
 - slit, 133
 - Talbot effect, 135
 - two pinholes, 158
- Diffusion equation, 1111, 1112
- Diode lasers, *see* Laser diodes
- Dipole
 - electric, 177
 - magnetic, 178
 - moment, 177, 178
 - wave, 177, 194
- Dirac equation, 565
- Directional coupler, 381, 984
 - integrated-photonic, 986
 - nonlinear, 1186
 - soliton router, 1187
- Dispersion, 184–191
 - compensating fiber, 423
 - flattened fiber, 423
 - shifted fiber, 422
 - angular, 1096
 - anomalous, 202
 - chromatic, 422
 - coefficient, 201, 202, 419
 - compensation, 685, 1110, 1111, 1254
 - diffraction analogy, 1112
 - diffractive, 1096
 - group velocity, 201, 207, 370, 425, 550, 1104
 - in multi-resonance medium, 204
 - interferometric, 1096
 - management, 1255
 - material, 419, 1096
 - material and modal, 420
 - measures, 185
 - modal, 370, 389, 418, 1096
 - multipath, 1096
 - nonlinear, 425, 1096
 - normal, 202
 - optical-fiber, 418–426
 - polarization mode, 423, 1096
 - pulse propagation with, 199–203
 - spatial, 1096
 - waveguide, 421, 1096
- Dispersion relation
 - anisotropic medium, 234–237
 - photonic crystal, 282, 285, 296
 - waveguide, 359, 370
- Dispersive medium
 - anisotropic and nonlinear, 1073
 - four-wave mixing, 1074
 - nonlinear optics of, 1069–1074
 - three-wave mixing, 1073, 1076, 1162
- Distributed Bragg reflector, 269, 434, 466, 471, 798
 - fiber, 687, 692, 720
 - laser, 843
- Doped dielectric media, 568–572
 - actinide metals, 572
 - lanthanide metals, 571, 572
 - transition metals, 569
- Doppler
 - effect, 75
 - radar, optical, 75
 - shift, 950
- Double refraction, 238–239, 254
- Double-slit experiment, 65, 493, 525
 - Michelson stellar interferometer, 505
 - role of source size, 495
 - role of spectral width, 495
- Downconversion, 1077
- Downconversion, parametric, 1027
- Drude model, 322–326, 388
 - group velocity, 352
 - simplified, 324–326
- Drude, Paul Karl Ludwig, 303
- Drude–Lorentz model, *see* Drude model
- Efficiency
 - absorption, 199
 - differential power-conversion, 670
 - external, 800
 - external differential, 836, 838
 - extraction, 670, 838
 - internal, 754, 796, 838
 - optical-to-optical, 671
 - optical-to-optical slope, 671
 - overall, 670

- photon detection, 876
 - power-conversion, 670, 837, 838
 - scattering, 196
 - slope, 670, 837
 - wall-plug, 670, 838
 - Eigenvalue problem, 220, 279, 563, 1301
 - Eikonal equation, 26, 52, 343, 407
 - Einstein
 - \mathbb{A} and \mathbb{B} coefficients, 591
 - postulates, 591
 - Einstein, Albert, 515, 561, 871
 - Electric
 - dipole, 177
 - dipole moment, 177
 - field, 162
 - field, internal, 196
 - flux density, 163
 - Electro-optic devices
 - directional coupler, 381, 984
 - dynamic wave retarder, 980
 - intensity modulator, 981, 995, 1014
 - interferometric photonic switch, 1192
 - liquid-crystal SLM, 1002–1005
 - phase modulator, 973, 979, 995, 1013, 1014
 - self-electro-optic-effect device, 1220
 - spatial light modulator, 987–989
 - strain sensor, 1013
 - switch, 985
 - Electro-optics, 975–1014
 - anisotropic media, 989–996
 - double refraction, 1014
 - index-ellipsoid modification, 989
 - introduction to, 976–977
 - Kerr effect, 978, 994, 1037, 1077
 - Pockels effect, 978, 991–994, 1024, 1077
 - principles of, 977–989
 - Electroabsorption, 1010–1012
 - Franz–Keldysh effect, 1010
 - modulator, 1010, 1011
 - switch, 1010
 - Electrochromism, 1009
 - Electroluminescence, 608, 789
 - injection, 609, 790
 - Electromagnetic optics, 160–208
 - constitutive relation, 166
 - introduction to, 161–162
 - material equation, 173
 - relation to wave optics, 180
 - Electromagnetic wave
 - amplitude-modulated, 207
 - dipole wave, 177, 194
 - energy, 165
 - energy density, 176
 - Gaussian beam, 179
 - in a medium, 163
 - in absorptive medium, 181, 309–310
 - in anisotropic medium, 170
 - in conductive medium, 320–326
 - in dielectric medium, 166–180
 - in dispersive medium, 170, 184, 199
 - in double-negative medium, 308
 - in double-positive medium, 308
 - in free space, 162
 - in inhomogeneous medium, 168, 174
 - in negative-index material, 314
 - in nonlinear medium, 171
 - in resonant medium, 186
 - in single-negative medium, 308
 - intensity, 165, 172, 176
 - momentum, 165
 - monochromatic, 172–180
 - plane wave, 175, 307
 - power, 165, 172
 - Poynting vector, 165
 - scattered, 194, 196
 - spherical wave, 177
 - TEM wave, 175, 307
 - traveling standing, 207
 - vector beam, 180
- Electron configuration, 566
- actinide metals, 569
- He, 566
- lanthanide metals, 569
- Ne, 566, 701
- Ne⁺, 701
- Ne-like, 699
- Ni-like, 699
- rare-earth elements, 569
- transition metals, 569
- Electroweak theory, 515
- Elements
 - actinide metals, 569, 572
 - lanthanide metals, 569, 571
 - periodic table, 566, 567
 - rare-earth, 571, 682, 687
 - semiconductor, 686
 - transition metals, 569, 745
- Energy
 - activation, 885
 - anisotropic transport, 234–237
 - density, electromagnetic, 176
 - electromagnetic, 165, 172
 - optical, 44
 - photon, 518
- Energy levels
 - alexandrite, 570

- azimuthal quantum number, 564
 bandgap energy, 576, 578, 733, 738
 Bohr atom, 564
 Boltzmann distribution, 581
 C^{5+} , 564
 CO_2 molecule, 574
 conduction band, 576
 Cr^{3+} :crysoberyl, 570
 Cr^{3+} :sapphire, 570
 crystal-field theory, 570
 degeneracy, 572, 582
 diatomic molecules, rotating, 573
 diatomic molecules, vibrating, 573
 dye molecule, 575
 Fermi–Dirac distribution, 582
 fine structure, 565
 forbidden band, 576
 H, 564
 He, 566
 hyperfine structure, 565
 ionization energy, 568
 ions, 568–572
 lanthanide-ion manifolds, 572
 ligand field theory, 570
 magnetic quantum number, 564
 manifold, 566, 572, 634, 683
 molecular, 573
 multielectron atoms, 565–568
 Nd^{3+} :glass, 571, 595
 Nd^{3+} :YAG, 571, 595
 Ne, 566
 occupation, 581
 principal quantum number, 564
 quantum dots, 580
 relativistic effects, 565
 rotational quantum number, 573
 ruby, 570
 spin–orbit coupling, 565
 Stark splitting, 568, 601, 1010
 triatomic molecule, vibrating, 574
 valence band, 576
 vibrational quantum number, 573
 vibrational–rotational, 574
 Zeeman splitting, 568, 599, 601
- Etalon
 Fabry–Perot, 69, 265–269, 679, 728
- Evanescence wave
 amplified, 316
 at DPS-DPS boundary, 224
 at DPS-SNG boundary, 310
 decay, 120, 146
 nanolaser, 862
 near-field imaging, 146
 waveguide, 368
- Excess noise factor
 CAPD, 917, 920, 940
 dark-noise, 921
 dead-space APD, 918
 definition, 911, 916
 modified, 920
 photoconductive detector, 940
 PMT, 916, 920, 940
 position-dependent APD, 919
 relation to gain variance, 916
 SACM APD, 918
 SAM APD, 918
 SCIDCM CAPD, 940
 SCISCM CAPD, 940
 staircase APD, 919–921
 superlattice APD, 921
- Excitons
 bulk semiconductors, 767
 electroabsorption, 1010
 organic semiconductors, 784, 810
 quantum dots, 580, 850
 quantum-confined, 779
- Extinction
 coefficient, field, 198, 311, 312, 368
 coefficient, intensity, 198
 coefficient, waveguide, 368
 ratio, 983
- Fabry, Charles, 433
 Fabry–Perot
 etalon, 69, 265–269, 471, 679, 728
 finesse, 69, 266, 441, 443
 free spectral range, 267, 438, 446
 internal intensity, 68, 441
 loss coefficient, 443
 loss factor, 443, 444
 losses, 440, 442–446
 modal spectral width, 442
 off-axis modes, 446
 photon lifetime, 444, 471
 quality factor, 445
 resonance frequencies, 437, 446
 resonator, 69, 265, 436–446, 661
 spectral width, 440
 transmittance, 266–268
- Faraday
 effect, 242–243
 rotator, 250, 1173
- Fast light, 204
- Fermat's principle
 maximum time, 38
 minimum time, 6
- Fermat, Pierre de, 3
- Fermi

- Dirac distribution, 582, 747
- energy, 582
- function, 582, 746
- inversion factor, 777
- level, 747, 748, 785
- tail, 748
- velocity, 744
- Fermion, 524, 565, 568
- Dirac-, 744
- Fiber optics, 391–432
 - infrared, 429
 - introduction to, 392–393
- Fiber, optical, 18, 19
 - λ parameter, 399
 - absorption bands, 416
 - acceptance angle, 19, 25, 395
 - attenuation, 415
 - Bragg grating, 269, 687, 692, 720
 - characteristic equation, 400
 - chromatic dispersion, 422
 - cladding, 392
 - communications, 1224–1286
 - core, 392
 - coupler, 414, 432
 - differential group delay, 423, 425
 - dispersion, 418–426
 - dispersion relation, 400
 - dispersion-compensating, 423, 1110
 - dispersion-flattened, 423
 - dispersion-shifted, 422
 - extrinsic absorption bands, 417
 - fiber optics, 391–432
 - fiber parameter, 399
 - grade-profile parameter, 396, 412
 - graded-index, 392, 396, 409, 432
 - group velocity, 404, 412, 432
 - guided rays, 393–397
 - guided waves, 397–415
 - holey, 256, 426–428
 - hybrid, 429
 - infrared, 429
 - introduction to fiber optics, 392–393
 - material and modal dispersion, 420
 - material dispersion, 419, 432
 - materials, 429–430
 - meridional ray, 394
 - metamaterial, 428
 - modal dispersion, 392, 418, 432
 - mode cutoff, 402
 - modes, 400, 409, 432
 - multicore, 413, 1263
 - multicore couplers, 413
 - multimode, 392
 - nonlinear dispersion, 425
- number of modes, 403, 410
- numerical aperture, 19, 395
- optimal index profile, 412
- photonic lantern, 414
- photonic-crystal, 426–428
- polarization mode dispersion, 423
- polarization-maintaining, 406
- power transmission ratio, 416
- propagation constant, 404, 411, 432
- quasi-plane wave solutions, 407, 432
- second-harmonic generation, 1023
- silica-glass, 392
- single-mode, 392, 405
- skewed ray, 394
- specialty, 429
- SPM, 1130
- step-index, 392–396, 398–405, 408
- waveguide, 392
- waveguide dispersion, 421
- Finesse, 69, 266, 441
- First-order optics, *see* Paraxial optics
- Fluorescence, 609, 811
 - fluorophore, 610
 - three-photon, 610
 - two-photon, 610
 - up-conversion, 610, 611
- Focal length
 - arbitrary paraxial system, 31
 - cylindrical lens, 17
 - Fresnel zone plate, 67, 118
 - optical Kerr lens, 1039
 - paraboloidal mirror, 9
 - pulse focusing system, 1110
 - spherical lens, 16, 17
 - spherical mirror, 11
 - time lens, 1113
- Focal point
 - SEFOC lens, 24
 - arbitrary paraxial system, 31
 - cylindrical lens, 346
 - paraboloidal mirror, 8
- Four-wave mixing, 1042, 1059, 1074
 - degenerate, 1044, 1045
 - in supercontinuum generation, 1140
 - switch, photonic, 1199
- Fourier optics, 110–159
 - amplitude modulation, 116
 - far-field Fourier transform, 124–126
 - Fourier transform via lens, 158, 549
 - free-space impulse response, 122
 - free-space propagation, 113–123
 - free-space transfer function, 119, 316
 - frequency modulation, 116
 - Fresnel approximation, 120–121

- Fresnel zone plate, 118
- Huygens–Fresnel principle, 123
- imaging, 117
- impulse response function, 112
- introduction to, 111–112
- optical Fourier transform, 124–128
- periodic media, 286–289
- plane wave, 113
- pulsed waves, 1117
- scanning, 117
- spatial frequency, 111
- spatial frequency and angle, 113
- spatial harmonic function, 113
- spatial spectral analysis, 114
- transfer function, 112
- Fourier transform
 - autocorrelation, 1288
 - circularly symmetric function, 1294
 - convolution, 1288, 1294
 - correlation, 1288
 - far-field, 124–126
 - one-dimensional, 1287–1293
 - optical, 124–128, 1118
 - pairs, 1289
 - Parseval’s theorem, 914, 1288
 - properties, 1288, 1294
 - separable functions, 1294
 - short-time, 1083
 - spectroscopy, 491
 - table, 1289
 - two-dimensional, 1293–1295
 - using lens, 126–128, 158
 - window function, 1083
- Fourier, Jean-Baptiste Joseph, 110
- Franken, Peter, 1015
- Franz–Keldysh effect, 1010
- Fraunhofer
 - approximation, 124
 - diffraction, 130–132, 158, 1090
- Fraunhofer, Josef von, 110
- Frequency
 - resolved optical gating, 1156
 - beat, 74, 967, 1153, 1267
 - conversion, 1027, 1054
 - instantaneous, 1081
 - modulation, spatial, 116
 - of light, 42
 - shifter, acousto-optic, 967
- Fresnel
 - approximation, 49, 120–121, 1118
 - biprism, 14, 57
 - diffraction, 132–137, 158, 1090
 - equations, 223, 253, 258
 - integrals, 134
 - lens, 18
 - number, 50, 121, 125, 458
 - reflection, 639, 797
 - zone plate, 67, 118
- Fresnel, Augustin-Jean, 210
- Gabor, Dennis, 110
- Gain
 - amplifier, parametric, 1056
 - amplifier, reflection, 1065
 - CAPD, 896
 - conversion, 1271
 - laser amplifier, 623
 - laser diode, 834
 - photoconductive detector, 884
 - Raman, 642, 1041
 - saturated, 647, 649
 - SCIDCM CAPD, 898, 940
 - SCISCM staircase APD, 940
 - secondary-emission, 916
 - semiconductor optical amplifier, 818
- Gain coefficient
 - amplifier, parametric, 1057
 - peak, 821, 832, 869
 - quantum-well SOA, 828
 - Raman, 1041
 - saturated, 646, 649, 660
 - small-signal, 622, 660
 - SOA, 820
- Gate, photonic logic, 1165, 1211
- Gauss, Carl Friedrich, 79
- Gaussian
 - chirped pulse, 1084–1085
 - pulse, 1084, 1161
 - pulse, Gaussian-beam analogy, 1113
- Gaussian beam, 51, 80–99
 - M^2 factor, 90
 - $ABCD$ law, 97–99
 - q -parameter, 81, 97
 - Bessel-beam comparison, 106
 - characterization, 88
 - collimation, 95
 - complex amplitude, 80–82, 123
 - complex envelope, 81
 - confocal parameter, 85
 - depth of focus, 85
 - divergence angle, 85, 109
 - elliptic, 102, 109
 - expansion, 95
 - focusing, 93, 109, 1122
 - Gaussian-pulse analogy, 1113
 - Gaussian-pulsed, 1120
 - Gouy effect, 86
 - intensity, 82

- parameters, 89, 90, 108
- paraxial approximation, 89
- phase, 86
- power, 83
- properties, 82–91, 451
- pulsed, 1087
- quality, 90
- radius of curvature, 86
- Rayleigh range, 81
- reflection from spherical mirror, 96
- relaying, 94
- shaping, 93
- single-photon, 522
- spherical-mirror resonator, 451, 453
- spot size, 84, 109
- standing wave, 471
- through arbitrary system, 97
- through components, 91–99
- through free space, 98
- through graded-index slab, 109
- through thin lens, 91–93
- through transparent plate, 99
- vector, 179
- waist radius, 84
- wavefronts, 86
- width, 84
- Gaussian optics, *see* Paraxial optics
- General Electric Corporation, 787
- Geometrical optics, *see* Ray optics
- Goos–Hänchen effect
 - shift, 253
 - waveguide, 371
- Gordon, James P., 1078
- Gouy effect, 86
- Graded-index
 - GRIN material, 20, 343
 - SEFOC slab, 23
 - fiber, 24, 40, 396–397, 409
 - lens, 24
 - optics, 20–25, 343
 - ray equation, 20–21
 - ray equation, paraxial, 21
 - slab, 22
- Graphene photonics, 719, 744
- Grating
 - coulpler, 377
 - diffraction, 59, 78
- Grazing incidence, 223, 311, 434, 698
- Group
 - delay, 200
 - index, 201
 - velocity, 200, 352
 - velocity dispersion, 201, 207, 370, 425, 550, 1104
- velocity, fiber, 404, 412
- velocity, photonic crystal, 284
- velocity, waveguide, 360, 370
- Group-IV photonics, 737, 743
- 2D materials, 745, 780
- allotropes, 743
- array detector, 909
- avalanche photodiode, 902
- GeSn-on-Si laser, 860
- graphene photonics, 719, 744
- microcavity laser, 859
- photodiode, 892
- Schottky-barrier photodiode, 894
- SiC Schottky diode, 809
- silicon photonics, 780, 808
- transition-metal dichalcogenides, 745
- Guided-wave optics, 353–390
- Gyration vector, 241
- Harmonic oscillator, 170, 323, 1072, 1298
 - analogy with optical mode, 543
 - energy, 542
 - quantum theory, 542, 543, 573
- Heaviside, Oliver, 164
- Helmholtz equation, 46, 81, 173, 192
 - coupled, 954, 1049, 1060
 - coupled paraxial, 1050
 - generalized, 257, 343, 1304
 - nonlinear, 1134
 - optical fiber, 397
 - paraxial, 51, 78, 81, 102
 - two-dimensional, 105
- Hermite polynomials, 100, 542
- Hermite–Gaussian beam, 99–102, 105
 - axial phase, 109
 - complex amplitude, 101
 - elliptic, 102
 - excess phase, 101
 - Hermite polynomials, 100
 - Hermite–Gaussian functions, 101
 - intensity, 102
 - power confinement, 109
 - superposition, 103, 109
- Hermite–Gaussian functions, 542
- Hermitian operator, 1302
- Hero’s principle, 6
- Hertz, Heinrich, 871
- Heterodyne
 - optical, 74, 545, 967, 1153, 1267
- Heterostructures
 - organic semiconductors, 810
 - photoconductor, 886
 - photodiode, 891
 - SOAs, 825

- High-harmonic generation, 1141–1145
 in Ar, 1144
 optical frequency comb, 723
 recollisional model, 1141, 1145
- Hilbert transform, 625, 1298
- Hole burning
 spatial, 673
 spectral, 651, 674
- Hologram, 148
 computer-generated, 155
 grating vector, 153
 holographic optical element, 155
 interconnection, 1222
 interconnection capacity, 1170
 Laguerre–Gaussian beam, 104, 155
 metasurface, 342
 oblique plane wave, 149, 159
 point source, 149, 155, 159
 rainbow, 154
 volume, 153
- Holography, 147–155
 ambiguity term, 150
 apparatus, 152
 computer-generated, 155, 1171
 dynamic, 1009
 Fourier-transform, 150
 hologram, 148
 holographic code, 148
 object wave, 148
 off-axis, 150
 optical correlation, 159
 real-time, 1045
 reconstructed wave, 149
 reference wave, 148
 spatial filters, 151
 surface-relief, 1172
 volume, 153
- Huygens, Christiaan, 41
- Huygens–Fresnel principle, 123, 193
- Hyperbolic
 media: Type-I & Type-II, 352
 medium, 317–320
 metamaterial, 339–340, 352
- IBM Corporation, 787
- Imaging, 137–147, 499
 2-*f*, 127, 549
 4-*f*, 139
 4-*f* impulse response function, 141
 4-*f* system transfer function, 139
 diffraction limit, 146
 equation, 11, 17, 32, 58, 138, 315
 equation, incoherent light, 499
 focal-plane array (FPA), 907
- functional, 610
- hyperbolic medium, 318–319
- image intensifier, 875
- incoherent light, 499–502
- incoherent vs. coherent, 500–502
- multiphoton microscopy, 611
- near-field, 146, 334
- negative-index slab, 315–317
- optical correlation, 159
- paraxial system, 31
- perfect, 315, 318
- phase object, 158
- point-spread function, 499
- scanning near-field microscopy, 147
- single-lens, 58, 137, 141, 500
- single-lens impulse response function, 141, 500
- single-lens transfer function, 144
- single-photon, 522
- spatial filtering, 141, 159
- spherical mirror, 11
- structural, 610
- subwavelength, 146, 315, 334
- thick lens, 32
- thin lens, 31
- three-photon microscopy, 611
- two-photon, 549, 550
- two-photon microscopy, 610
- two-point resolution, 159
- X-ray, 705
- Impedance, 176
 complex, 183
 imaginary, 308, 310
- Impermeability, electric
 effect of electric field, 990
 in magneto-optic material, 243
 tensor, 230, 989
- Impulse response function, 1296, 1299
 4-*f* imaging, 141
 free space, 122
 incoherent light, 499
 single-lens imaging, 137, 141, 500
- Ince–Gaussian beam, 105
- Incoherent light, *see* Coherence
- Index ellipsoid, 230, 232–233, 989
 acoust-optic modification, 968–970
 electro-optic modification, 989–990
- Index of refraction, *see* Refractive index
- Infrared
 frequencies, 42, 853
 LWIR band, 42, 853
 molecular-fingerprint region, 853
 MWIR band, 42, 853
 optical fiber, 429

- sensor card, 612
- wavelengths, 42, 853
- Injection lasers, *see* Laser diodes
- Instantaneous frequency, 1081
- Insulators
 - band structure, 577
- Integrated
 - optics, 354, 375, 808
 - photonics, 354, 375, 808
- Intensity
 - autocorrelation function, 1150
 - average, 475
 - Bessel beam, 106
 - Bessel-like beam, 107
 - electromagnetic, 165, 172, 176
 - elliptic Gaussian beam, 102
 - Gaussian beam, 82, 106
 - Hermite–Gaussian beam, 102
 - instantaneous, 476
 - irradiance, 44, 812
 - Laguerre–Gaussian beam, 103
 - measurement for pulse, 1146
 - optical, 44, 46
 - partially coherent light, 475
 - polychromatic light, 72
 - random, 476
 - scattered, 193, 194
 - spectral density, 480
- Interconnect, optical, 1166–1178
 - circulator, 1168, 1173
 - computer-com, 1174–1177
 - diffractive, 1168
 - free-space, 1168–1172
 - guided-wave, 1172
 - holographic, 1177
 - inter-board, 1174
 - inter-chip, 1174
 - interconnection matrix, 1166
 - intrachip, 1176
 - introduction to, 1164–1165
 - isolator, 1167
 - nonreciprocal, 1167, 1173
 - nonreciprocal, multiport, 1167
 - optochip, 1174
 - rationale, 1177
 - refractive, 1168
- Interference, 61–71, 489–496
 - Bragg reflection, 67
 - double-slit experiment, 65, 493, 525
 - equation, 61, 489
 - finite number of waves, 66, 1183
 - Fourier-transform spectroscopy, 491
 - Fresnel zone plate, 67
 - infinite number of waves, 68
 - light from extended source, 495
 - multiple waves, 65–71, 75
 - oblique-plane-wave, 64
 - OCT, 492
 - partially coherent light, 489–496
 - plane-wave and spherical-wave, 64
 - QOCT, 550
 - single-photon, 525, 555
 - spherical-wave, 65, 493
 - two-photon, 550
 - two-wave, 61, 74, 489
 - visibility, 78, 490
- Interferometer, 62–71
 - double-slit, 65, 493, 495, 505, 512, 525
 - Fabry–Perot, 69, 70
 - Fabry–Perot, nonlinear, 1217
 - finesse, 69, 266, 441
 - gravitational-wave, 70–71, 545
 - gyroscope, 63
 - Hong–Ou–Mandel, 550
 - interferogram, 491
 - LIGO, 70, 545
 - Mach–Zehnder, 62, 1181
 - Michelson, 62, 70, 75, 78, 491
 - Michelson stellar, 505
 - multipath, 66, 1183
 - MZI, NL, 1185, 1216, 1218, 1223
 - nonlinear, 1154, 1156, 1162
 - role of spatial coherence, 493
 - role of temporal coherence, 490
 - Sagnac, 62
 - Sagnac, nonlinear, 1185, 1201
 - self-referenced spectral, 1154
 - single-photon, 526
 - spectral, 1153
 - stellar, 505
 - temporal, 74, 1153
- Invisibility cloak, 347–348
 - metamaterials, 348
- Ionization
 - coefficients, 895
 - coefficients, history-dependent, 903
 - coefficients, position-dependent, 903
 - energy of a donor electron, 742
 - energy of an atom, 568
 - energy of Ar, 1144
 - energy of H, 564, 568, 742
 - ratio, 896
- Ions
 - actinide metals, 572
 - electron configuration, 569
 - lanthanide metals, 568, 571, 572
 - noble-gas lasers, 568

- term symbol, 569
- transition metals, 569
- Irradiance, 44, 812
- Isolator, optical, 250, 967, 1167
- John, Sajeev, 255
- Jones matrix, 217–221
 - cascaded devices, 219, 253
 - coordinate transformation, 219
 - diagonal, 222
 - field version, 509
 - half-wave retarder, 219, 220
 - linear polarizers, cascaded, 254
 - normal modes, 220
 - polarization rotator, 219, 549
 - polarizer, 217, 253
 - quarter-wave retarder, 218
 - wave retarder, 218, 253
 - wave-retarder cascade, 219, 253
- Jones vector, 215–221
 - coordinate transformation, 219
 - field version, 507
 - normal modes, 220
 - orthogonal expansion, 215, 216
 - two-photon, 547, 548
- Kaminow, Ivan Paul, 1224
- Kao, Sir Charles Kuen, 1224
- Keck, Donald B., 391
- Kerr
 - coefficient, 978, 1037, 1077
 - effect, 978, 994, 1037
 - lens, 1039
 - medium, 1036, 1129, 1149
 - medium characteristic length, 1130
 - switch, 1148
- Kerr, John, 975
- Kramers–Kronig relations, 186, 1298
- Laguerre
 - Gaussian beam, 102–105, 155
 - generalized polynomial, 103
 - polynomial, 103
- Laguerre, Edmond Nicolas, 79
- Laser, 657–730
 - Q -switched, 708, 712, 716, 730
 - Ag^{19+} , 700, 706
 - alexandrite, 570, 645, 706
 - Ar^+ -ion, 568, 645, 678, 706, 720
 - ArF exciplex, 645, 706
 - Brillouin fiber, 692
 - broadening, homogeneous, 672
 - broadening, inhomogeneous, 673
 - C^{5+} , 645, 699, 706
 - cascaded Raman fiber, 692
 - cascaded silicon Raman, 692
 - cavity dumping, 708, 730
 - ceramic hosts, 681
 - chemical, 696
 - CO, 854
 - CO_2 , 645, 706, 720, 854
 - coherent-state generation, 544
 - cooling, 599
 - $\text{Cr}^{2+}:\text{ZnS}$, 645, 686, 706, 854
 - $\text{Cr}^{2+}:\text{ZnSe}$, 686, 854
 - $\text{Cr}^{3+}:\text{colquiriite}$, 682
 - $\text{Cr}^{3+}:\text{crysoberyl}$, 570, 645, 706
 - $\text{Cr}^{3+}:\text{sapphire}$, 570, 645, 657, 664, 681, 706, 716, 730
 - $\text{Cr}^{4+}:\text{forsterite}$, 645, 686, 706, 720
 - crystalline hosts, 681
 - $\text{Cu K}\alpha$, 645, 701
 - dopant ions, 681
 - DPSS, 682, 690, 789
 - dye, 696, 697
 - efficiency, 669
 - $\text{Er}^{3+}:\text{silica fiber}$, 645, 689, 706, 720
 - excimer, 695
 - exciplex, 695
 - extreme-ultraviolet, 697–702
 - $\text{Fe}^{2+}:\text{ZnS}$, 686
 - $\text{Fe}^{2+}:\text{ZnSe}$, 686
 - fiber, 687–691
 - four-level pumping, 630, 633
 - free-electron, 702–705
 - frequency pulling, 664
 - gain clamping, 666
 - gain switching, 707, 711, 730
 - gas, 695–696
 - glass hosts, 681
 - H_2O , 706
 - HAPLS, 640, 849, 1095
 - HCN, 706
 - He–Ne , 645, 706, 720
 - in-band pumping, 634, 686, 689, 697
 - incoherent-feedback, 693
 - InGaAsP, 645
 - inner-shell photopumped, 700
 - intracavity tilted etalon, 679
 - ion, 695
 - ionized-atom plasma, 699
 - Kr^+ -ion, 568, 706
 - KrF exciplex, 706
 - lasing without inversion, 663
 - linewidth, 680
 - loss coefficient, 661
 - metal-nanocavity, 863
 - methanol, 706

- microcavity, 854–862
- microdisk, 859
- microring, 859
- microring, coupled, 1219
- mode locking, active, 719
- mode locking, passive, 719
- mode-locked, 685, 709, 716–723
- molecular, 695
- MOPA, 688
- multiple-mirror resonator, 679
- multiquantum-dot, 850
- multiquantum-well, 845
- multiquantum-wire, 849
- nanocavity, 862–864
- nanoring, 863
- nanosphere, 864
- Nd³⁺:CaF₂, 572
- Nd³⁺:glass, 571, 595, 645, 706, 720
- Nd³⁺:YAG, 571, 645, 683, 706, 720
- Nd³⁺:YVO₄, 645, 682, 706
- Ne K α , 645, 701, 706
- non-plasmonic nanocavity, 863
- number of modes, 672
- optical vortex, 860
- oscillation conditions, 662
- oscillation frequencies, 664, 665
- output characteristics, 666–680
- overall efficiency, 706
- petawatt, 640, 849, 1095
- phase noise, 680
- phonon-terminated, 686
- photon lifetime, 662
- photonic-bandgap fiber, 688
- photonic-crystal, 860
- photonic-crystal array, 861
- plaser, 693
- plasmonic nanocavity, 863
- polarization, 677, 678
- powder, 693
- power-conversion efficiency, 706
- pulsed, 707–721
- pumping, 629, 635
- quantum cascade, 851–854
- quantum-confined, 844–854
- quantum-dot, 850
- quantum-well, 845
- quantum-wire, 849
- quasi-three-level pumping, 633
- quasi-two-level pumping, 634
- radar, 75
- Raman fiber, 691–692
- random, 693–695
- rate equations, 709
- rhodamine-6G dye, 645, 706, 720
- ribbon fiber, 688
- ruby, 570, 645, 657, 664, 681, 706, 716, 730
- SASE, 703
- Schawlow–Townes linewidth, 680
- Se²⁴⁺, 699
- seed, 688, 700, 701
- SGDFB, 853
- silicon Raman, 692, 809
- slab-waveguide fiber, 688
- solid-state, 681–686
- spatial distribution, 675
- spectral distribution, 671
- spontaneous lifetime, 644
- strained-layer QW, 846
- theory of oscillation, 659–665
- thin-disk, 683, 684, 706
- three-level pumping, 632, 633
- threshold, 662, 663, 698
- thresholdless, 861
- Ti³⁺:sapphire, 645, 685, 706, 720
- Tm³⁺:silica-fiber, 690, 706
- transient effects, 709–721
- transition parameters, 644
- trapping, 600
- two-level pumping, 655
- U³⁺:CaF₂, 572
- unipolar, 851
- unstable-resonator, 677
- vibronic, 570, 685, 686
- W⁴⁶⁺, 699
- wall-plug efficiency, 706
- wavelengths, 644, 706
- X-ray, 697–702
- X-ray free-electron, 704–706
- Yb³⁺:silica fiber, 639, 688, 706, 720
- Yb³⁺:YAG, 645, 729
- Yb³⁺:YAG thin-disk, 684, 706
- ZnO, 693, 694
- Laser amplifier, 619–656, 659
- ASE, 651–653, 699, 821, 830
- bandwidth, 624
- broadband, 655
- coherent, 620
- Doppler-broadened medium, 650
- Er³⁺:silica fiber, 641–642
- four-level pumping, 630, 633, 729
- gain, 623
- gain coefficient, 622, 660
- gain coefficient, saturated, 646, 649
- gain, saturated, 647, 649
- homogeneously broadened, 645–649
- in-band pumping, 634, 640, 642
- in-line, 636

- incoherent optical, 620
 - inhomogeneously broadened, 649
 - line, 636
 - MOFA, 636
 - MOPA, 636, 688
 - National Ignition Facility, 639, 688
 - Nd³⁺:glass, 638–640, 1095
 - noise, 651–653
 - nonlinearity, 645–651
 - optical fiber, 640–642
 - phase-shift coefficient, 625
 - photon statistics, 653, 656
 - population inversion, 582, 622–629
 - postamplifier, 636
 - power amplifier, 636
 - preamplifier, 636
 - pumping, 626–635
 - quasi-three-level pumping, 633
 - quasi-two-level pumping, 634
 - rare-earth-doped fiber, 640
 - rate equations, 626–629
 - rates and decay times, 626
 - ruby, 636–637
 - saturation, 645–651
 - saturation time constant, 629
 - spontaneous lifetime, 644
 - steady-state, 626
 - theory, 622–625
 - three-level pumping, 632, 633
 - transition characteristics, 644
 - two-level pumping, 655
 - wavelengths, 644
- Laser diodes (LDs), 831–844
- bipolar, 851
 - broad-area, 834, 848, 849
 - buried-heterostructure, 848
 - communications component, 1232
 - compare with LEDs, 839, 841
 - compare with SLEDs, 839, 841
 - confinement factor, 833
 - differential responsivity, 837
 - distributed Bragg reflector, 842
 - distributed-feedback, 842, 848
 - double-heterostructure, 825, 845
 - efficiency, 836
 - external differential efficiency, 836
 - external-cavity, 843
 - extraction efficiency, 838
 - far-field radiation pattern, 842
 - gain condition, 834
 - gain-guided, 834
 - Ge, 772
 - GeSn-on-Si, 860
 - group-IV, 859
 - III–antimonide, 854
 - III–V quantum-dot-on-Si, 859
 - in-band pumping, 817
 - index-guided, 834
 - interband, 851
 - interband cascade, 854
 - IV–VI, 854
 - lead-salt, 854
 - light-current curve, 837, 839
 - linewidth, 843
 - linewidth-enhancement factor, 843
 - mode-locked, 844
 - multimode MQW, 848
 - PbSnSe, 854
 - PbSnTe, 854
 - phase noise, 843
 - power output, 836
 - power-conversion efficiency, 838
 - ridge-waveguide, 847
 - Schawlow–Townes linewidth, 843
 - single-mode, 842
 - single-mode MQW, 847
 - slope efficiency, 837
 - spatial characteristics, 841
 - spectral characteristics, 839
 - threshold, 834
 - VCSEL, 856–858
 - VECSEL, 721, 859
 - wall-plug efficiency, 838
 - wavelength-tunable, 843
- Layered media, 258–276
- off-axis wave, 264
- Lens, 16–18
- aspheric, 17
 - biconcave, 17
 - biconvex, 17
 - collimating, 95
 - compound, 17
 - converging, 17
 - cylindrical, 17, 24, 40, 117, 118
 - diverging, 17
 - dome, 799, 814, 815
 - double-convex, 58
 - electro-optic, 976
 - expanding, 95
 - focal length, 16
 - focal point, 33
 - focusing, 58, 93, 109
 - Fourier transform, 126, 128, 158, 513, 549
 - Fresnel, 18
 - Fresnel zone plate, 67, 118
 - graded-index, 24, 60
 - hyperlens, 319

- imaging, 58, 137, 139, 141, 158, 500
- Kerr, 719, 1039
- LED, 799
- meniscus, 17
- perfect, 315–317
- plano-concave, 17
- plano-convex, 17, 58
- principal point, 33
- relaying, 94
- sequence, 36, 37
- shaping, 93
- spherical, 16
- superlens, 316
- thick, 33
- thin, 57, 91
- time, 1113, 1162
- vertex point, 33
- Lidar, 789
 - coherent, 75
 - PIC, 1238
- Light
 - classical, 4, 539
 - guide, 18
 - interaction with atoms, 583–602
 - interaction with semiconductors, 766
 - line, 285
 - nonclassical, 4, 539, 544, 546
- Light-emitting diodes (LEDs), 789–817
 - additive color mixing, 814–815
 - AMOLED, 1004
 - arrays, 815
 - bioinspired, 798
 - Ce³⁺:YAG phosphor, 814
 - characteristics, 794–803
 - chip-on-board (COB), 815
 - color rendering index (CRI), 812
 - communications component, 1233
 - compare with incandescent, 812, 816
 - compare with LDs, 839, 841
 - compare with SLEDs, 839, 841
 - complementary colors, 813
 - correlated color temperature, 812
 - device structures, 803–817
 - die geometries, 798
 - discrete, 813
 - edge-emitting, 804
 - electronic circuitry, 803, 816
 - external efficiency, 800
 - extraction efficiency, 796, 869
 - illumination applications, 788, 811
 - indication applications, 788
 - infrared applications, 806
 - internal efficiency, 795, 800
 - light–current curve, 801, 839
 - lighting, 811–817
 - materials, 803–817
 - optics for, 15, 799
 - organic, 810, 816
 - output photon flux, 799
 - overall efficiency, 800
 - phosphor-conversion, 814
 - photonic-crystal, 798
 - plasmonic, 796
 - power-conversion efficiency, 800
 - quantum-dot, 807, 814
 - resonant-cavity, 800
 - response time, 802
 - responsivity, 801
 - retrofit lamps, 816
 - roughened-surface, 798
 - solid-state lighting, 811–817
 - spatial pattern, 799
 - spectral distribution, 802, 868
 - surface-emitting, 804
 - surface-mounted device, 814
 - trapping of light, 19, 39
 - ultraviolet applications, 808
 - visible applications, 807
 - wall-plug efficiency, 800
 - white, 813–815
 - WOLED, 810
- Line broadening, 593–597
 - collision, 595
 - Doppler, 597
 - homogeneous, 572, 595
 - inhomogeneous, 572, 595
 - lifetime, 593
- Linear system
 - causal, 1298
 - Hilbert transform, 1298
 - impulse response function, 1299
 - isoplanatic, 1299
 - Kramers–Kronig relations, 1298
 - modes, 1301–1305
 - one-dimensional, 1296–1299
 - point-spread function, 1299
 - shift-invariant, 1296, 1299
 - supermodes, 383
 - time-invariant, 1296
 - transfer function, 1297, 1300
 - two-dimensional, 1299–1300
- Lineshape function, 586
- Linewidth
 - enhancement factor, 843
 - laser, 680
 - laser diode, 843
 - Schawlow–Townes, 680, 843
 - transition, 586, 644

- Liquid crystal
 cholesteric, 244
 electro-optics of, 996–1005
 ferroelectric, 1001
 modulator, 997–1001
 nematic, 244, 996
 optics of, 244–246
 parameters, 999
 smectic, 244, 1001
 switch, photonic, 1194
 twisted nematic, 244–246, 999
 wave retarder, 997–1001
- Liquid-crystal display (LCD), 1002
 active matrix, 1003
 passive-matrix, 1002
 segmented, 1002
- Lithography
 electron-beam, 348, 468, 696
 EUV, 696, 702
 focused ion-beam, 348, 696
 holographic, 298
 micro-, 298
 multiphoton, 299, 611
 X-ray, 696
- LLNL, 639, 688, 698, 699, 849, 1095
- Localized surface plasmon, 330–332
 LED, 796
 nanolaser, 862
 resonance, 330
- Logic
 photonic logic gates, 1211
- Lorentz
 oscillator, 186, 1018, 1072
 relativistic factor, 703
- Lorentzian, 189, 483, 512, 593–595, 624, 625, 647, 730, 1080, 1292
- Luminescence, 607–612
 betaluminescence, 607
 bioluminescence, 608
 cathodoluminescence, 607, 618
 chemiluminescence, 608
 electroluminescence, 608
 fluorescence, 609, 811
 multiphoton fluorescence, 610
 phosphorescence, 609, 811
 photoluminescence, 609–612, 813
 radioluminescence, 609
 sonoluminescence, 607
 up-conversion fluorescence, 611
- Luminous
 efficacy, 812, 817
 flux, 812, 817
- Magnetic
 dipole moment, 178
 field, 162
 flux density, 163
- Magnetization density, 164
- Magneto-optics, 242–243
 Faraday effect, 242, 1013
 magnetogyration coefficient, 243
 switch, photonic, 1195
 Verdet constant, 243
- Magnification
 Gaussian beam, 92
 shift-variant, 144
 spherical boundary, 15
 spherical lens, 17
 spherical mirror, 11
 time lens, 1162
- Maiman, Theodore H., 657
- Manley–Rowe relations, 1029, 1051, 1063
- Maser, 659, 680
 astrophysical, 694
- Master-oscillator fiber-amplifier, 688
 examples, 689
- Master-oscillator power-amplifier
 examples, 636, 639, 688, 689
- Material
 double-negative (DNG), 306
 double-positive (DPS), 306
 equation, 173, 228, 241, 243
 hyperbolic, 317–320, 352
 left-handed, 306, 309
 negative-index (NIM), 309, 314–317
 single-negative (SNG), 306
- Matrix optics, 27–37
 $ABCD$ matrix, 28, 1302
 arbitrary paraxial system, 31
 Bragg grating, 271
 layered media, 258–276, 1303
 periodic media, 280–286
 periodic systems, 33–37, 447–450
 ray-transfer matrix, 27, 1302
 scattering matrix, 259–265
 scattering vs. wave-transfer, 260
 simple components, 29
 thick lens, 32
 transmission matrix, 380, 383
 wave-transfer matrix, 258–265, 1303
- Maurer, Robert D., 391
- Maxwell's equations
 boundary conditions, 164, 221
 complex permeability, 309–310
 complex permittivity, 309–310
 dielectric constant, 167
 electric field, 162
 electric flux density, 163

- impermeability tensor, 230
- in a medium, 163, 172
- in conductive medium, 320–326
- in free space, 162
- magnetic field, 162
- magnetic flux density, 163
- magnetization density, 164
- permeability, 163, 167, 306, 343
- permeability tensor, 343
- permittivity, 163, 167, 306
- permittivity tensor, 170, 228, 343
- polarization density, 164, 1017
- relative permittivity, 167
- speed of light, 163, 167
- vector potential, 177
- wave equation, 163, 167, 169, 171
- Maxwell, James Clerk, 160
- Media, *see* Materials
- Metals
 - band structure, 577
 - bound-electron absorption, 324
 - conductive media, 320–326
 - conductivity, 577
 - Drude model, 322–326
 - group velocity, 352
 - loss, 470
 - optics of, 304, 320–326
 - photoemission, 873
 - plasma frequency, 698
 - plasmonics, 320–334
 - reflectance, 324
 - work function, 873
- Metamaterials
 - holey metallic film, 342
 - hyperbolic, 339–340, 352
 - invisibility cloak, 348
 - metasurfaces, 340–343
 - negative-index, 338–339
 - negative-permeability, 337–338
 - negative-permittivity, 336–337
 - optical fiber, 428
 - optics of, 304, 334–343
 - photonic-crystal, 256, 334, 428
 - point-dipole approximation, 335
- Metameric white light, 813
- Metasurfaces, 340–343
 - complementary, 340
 - holey metallic film, 342
 - hologram, 342
 - phase modulator, 341
 - reflection, 342
 - refraction, 342
- Snell's law, modified, 342
- Michelson stellar interferometer, 505
- Micro-optics, 305, 1168
- Microcavity, *see* Microresonator
- Microcavity lasers, 854–862
- Microresonator
 - microcavity, 463
 - microdisk, 465
 - micropillar, 465
 - microsphere, 466–468
 - microrotoroid, 465
 - modal density, 465
 - modal volume, 464
 - photonic-crystal, 468
 - quality factor, 464
 - rectangular, 464–465
- Microscopy
 - multiphoton, 610, 611
 - near-field, 147
 - three-photon, 611
 - two-photon, 610
- Mie scattering, 197
- Miniband, 579, 764, 779, 852
- QCL, 852
- Mirror
 - collimator, 9
 - elliptical, 9
 - paraboloidal, 8, 10
 - planar, 8, 53, 78
 - spherical, 9, 30, 78, 96
 - variable-reflectance spherical, 97
- MIT Lincoln Laboratory, 787
- Mixing, optical, 74, 967, 1153, 1267
- Mode locking, 76, 709, 716–723
 - applications, 721
 - examples, 685–690, 696, 720
 - external-cavity LDs, 844
 - fiber lasers, 844
 - harmonic, 721
 - Kerr-lens, 719, 1039
 - methods, 719
 - optical frequency comb, 721
 - parameters, 718
 - properties, 716, 718, 730
 - QCLs, 721, 854
 - QD lasers, 851
 - saturable absorber, 719
 - SESAM, 719
 - VECSELs, 721, 859
- Modes
 - discrete linear system, 1302
 - eigenfunction, 1301
 - eigenvalue, 1301
 - eigenvector, 1301
 - homogeneous medium, 1305
 - integral operator, 1303

- linear system, 1301–1305
- normal, 1304
- ordinary differential equation, 1304
- partial differential equation, 1304
- periodic medium, 1305
- resonator, 1304
- supermodes, 383
- zero-point energy, 518, 573, 586
- Modulation**
 - amplitude shift keying, 1259
 - binary phase shift keying, 1259, 1273
 - constellation, 1259
 - differential phase shift keying, 1259
 - digital, 1258
 - field, 1257, 1266
 - frequency shift keying, 1259
 - intensity, 1258
 - multilevel coding, 1259
 - on-off keying, 931, 1259, 1272
 - phase shift keying, 1259
 - pulse code, 1258
 - quadrature amplitude, 1259
 - quaternary phase shift keying, 1259
 - spectral efficiency, 1259
- Modulator**
 - acousto-optic, 959
 - electroabsorption, 1010, 1011
 - intensity, 998
 - intensity, acousto-optic, 973
 - intensity, electro-optic, 981–983, 995
 - intensity, magneto-optic, 1013
 - intensity, push–pull, 1014
 - interferometric, 981
 - liquid-crystal, 997–1001
 - Mach–Zehnder, 981, 1014
 - multiquantum-well, 1010
 - optically addressed SLM, 1004
 - parallel-aligned SLM, 1005
 - phase, 998
 - phase, acousto-optic, 973
 - phase, cascaded, 1014
 - phase, electro-optic, 973, 979, 995
 - phase, opto-optic, 1076
 - quadratic phase, 1100
 - spatial light, 987–989
 - spatial light, acousto-optic, 965
 - spatial light, liquid-crystal, 1002
- Molecules**, 572–575
 - covalent bonding, 572
 - dye, 575
 - ionic bonding, 572
 - rotating diatomic, 573
 - van der Waals bonding, 572
 - vibrating diatomic, 573
- vibrating triatomic, 574
- Momentum**
 - electromagnetic, 165
 - localized photon, 523
 - localized wave, 523
 - photon, 523–524, 554, 555
 - radiation pressure, 524, 555
- Momentum, angular**
 - photon orbital, 524
 - photon spin, 524
- Mourou, Gérard**, 1078
- Multiphoton**
 - absorption, 1017
 - detection, 939, 1156, 1162
 - fluorescence, 610
 - lithography, 298, 299, 611
 - microscopy, 610, 611
 - photoluminescence, 610
- Multiple access**
 - code-division, 1276
 - frequency-division, 1276
 - time-division, 1276
- Multiplexing**
 - code-division, 1261
 - CWDM, 1263
 - DWDM, 1263
 - electronic, 1261
 - frequency-division, 1260
 - optical, 1261
 - space-division, 1263–1266
 - time-division, 1208, 1260
 - wavelength-division, 1179, 1262
- Multiquantum**
 - dot lasers, 850
 - well lasers, 845
 - wire lasers, 849
 - well, 764, 1010
- Nano-optics**, *see* Nanophotonics
- Nanocavity lasers**, 862–864
- Nanophotonics**, 193–199, 305, 326–343, 386–388, 428, 469–470
 - nanolasers, 862
 - subwavelength imaging, 147, 315
- Nanoresonator**, 469–470
 - metallic nanodisk, 469
 - metallic nanosphere, 470
- Nanosphere**
 - dielectric, 196–197
 - metallic, 330–332
 - scattering from, 196–197, 330–332
- Near-field imaging**, 146, 334
- Negative-index**
 - materials, 314

- metamaterials, 338–339
- Network, fiber-optic, 1274–1281
 - broadcast-and-select, 1277
 - bus, 1275
 - interface, 1276
 - local-area (LAN), 1274
 - mesh, 1275
 - multi-hop broadcast-and-select, 1278
 - ring, 1275
 - star, 1275
 - topologies, 1275
 - wavelength-routed, 1279
 - WDM, 1277
- Newton, Sir Isaac, 3
- Nobel laureates, 110, 160, 619, 657, 731, 867, 943, 1015, 1224
 - Nobel lectures, 157, 431, 551, 615, 616, 726, 727, 782, 783, 867, 868, 938, 972, 1075
- Noise
 - 1/f, 923
 - ASE, 651, 830
 - background, 911
 - circuit, 910, 922–930
 - dark-current, 911
 - gain, 910, 915
 - generation–recombination (GR), 940
 - laser phase, 843
 - optical amplifier, 651
 - photoconductor, 940
 - photocurrent, 912
 - photodetector, 909–923
 - photoelectron, 539, 910, 912
 - photon, 533–539, 910, 911
 - pink, 923
 - semiconductor optical amplifier, 821
 - shot, 518, 703, 912, 913
 - superluminescent diode, 830
 - thermal, 922
- Nondiffracting beams, 105–107
- Nondiffracting waves, 136
- Nonlinear optical coefficients, 1018, 1019, 1025, 1037, 1066, 1068
- Nonlinear optics, 171, 1015–1077
 - anharmonic oscillator, 1071–1073
 - anisotropic dispersive medium, 1073
 - anisotropic medium, 1066–1069, 1073
 - Born approximation, 1020, 1076
 - chi-two medium, 1021
 - coherence length, wave-mixing, 1032
 - coupled waves, 1047
 - coupled-waves, 1059, 1127
 - cross-phase modulation, 1041
 - DFG, 854, 1027
 - differential-equation description, 1071
 - dispersive medium, 1069–1074
 - downconversion, 1027, 1077
 - electro-optic effect, 1024
 - extreme, 1141
 - five-wave mixing, 1077
 - four-wave mixing, 1042, 1044, 1059, 1074, 1077, 1140
 - frequency conversion, 1027, 1054
 - HHG, 723, 1141
 - holography, real-time, 1045
 - idler, 1027
 - integral-transform description, 1070
 - introduction to, 1016–1017
 - Kerr effect, optical, 1037, 1042
 - Kerr medium, 1036
 - Manley–Rowe, 1029, 1051, 1076
 - Miller’s rule, 1073
 - nonlinear coefficients, 1018, 1019, 1025, 1037, 1066, 1068
 - nonparametric, 1017, 1028
 - parametric, 1017
 - parametric interactions, 1026–1029
 - periodic poling, 1035, 1036
 - phase conjugation, 1044, 1063
 - phase matching, 1026, 1029–1033
 - phase-mismatching tolerance, 1076
 - photonic-crystal soliton, 1141
 - plane-wave conjugation, 1045
 - polarization density, 1017–1019
 - poling, 1036
 - pump, 1027
 - quasi-phase matching, 1034, 1076
 - Raman gain, 1041
 - rectification, optical, 1023
 - rectification, pulsed optical, 1128
 - refraction, nonlinear, 1038
 - scattering theory, 1020, 1076
 - Schrödinger equation, nonlinear, 1040, 1135, 1138
 - second-order, 1021–1036, 1047–1059
 - self-focusing, 1039
 - SFG, 1027
 - SFG and SHG combined, 1077
 - SHG, 1021, 1027, 1049, 1051
 - SHG efficiency, 1022, 1052
 - SHG phase mismatch, 1053
 - signal, 1027
 - solitary wave, 1131
 - soliton self-frequency shift, 1140
 - soliton, spatial, 1039
 - soliton, spatiotemporal, 1139
 - soliton, temporal, 425, 1130–1139
 - SPDC, 548, 1027

- spherical-wave conjugation, 1045
- SPM, 425, 1038, 1129, 1130, 1140
- supercontinuum generation, 1139
- THG, 1037, 1063
- third-order, 1036–1047, 1059–1066
- three-wave mixing, 545, 1025, 1026, 1043, 1050, 1061, 1066, 1073, 1076, 1077, 1127, 1162
- THz pulse generation, 1128
- tuning curves, 1029
- two-wave mixing, 1009, 1026, 1042
- ultrafast, 1126–1145
- up-conversion, 1054, 1055
- Volterra-series expansion, 1070
- walk-off effect, 1126
- wave equation, 1019, 1047, 1133
- wave restoration, 1046
- Nonlinear-optic devices
 - amplifier, parametric, 1027, 1056
 - amplifier, phase-sensitive, 1062
 - amplifier, reflection, 1065
 - amplifier, transmission, 1065
 - DFG, 1027
 - downconverter, 1027, 1077
 - FPI, 1217, 1218
 - intensity autocorrelator, 1150, 1162
 - lens, optical Kerr, 1039
 - loop mirror, 1186
 - modulator, opto-optic phase, 1076
 - MZI, 1216, 1218
 - oscillator, doubly resonant, 1058
 - oscillator, parametric, 1027, 1057
 - oscillator, phase-conjugation, 1066
 - oscillator, singly resonant, 1058
 - router, directional-coupler, 1186
 - router, nonlinear MZI, 1185
 - router, nonlinear Sagnac, 1185
 - router, soliton, 1187
 - SFG, 1027
 - streak camera, 1149
 - switch, FWM, 1199
 - switch, optical Kerr, 1148, 1198
 - switch, photonic, 1196–1211
 - switch, Sagnac, 1201
 - switch, SFG, 1197
 - switch, SHG, 1147
 - switch, XPM, 1197–1199
 - up-converter, 1027
- Nonparametric processes, 1028
- Normal modes
 - anisotropic medium, 230, 232–233
 - optically active medium, 241
 - polarization system, 220, 221
- Numerical aperture, 19, 25, 39, 181, 366, 395, 432
- Ohm's law, 320, 882
- Optical
 - frequency comb, 721, 1141
 - Kerr effect, 1037, 1042
 - lattices, 601
 - molasses, 599
 - OADM, 1179, 1180, 1279
 - pathlength, 5, 6, 53, 78
 - phase conjugation, 1044, 1063
 - sectioning, 492, 550
 - tweezers, 600
- Optical activity, 240–242
 - gyration vector, 241
 - normal modes, 241
 - rotatory power, 242
- Optical coherence, *see* Coherence
- Optical coherence tomography, 492
 - frequency-domain, 493
 - quantum, 550
 - time-domain, 492
- Optical components, 8–20, 53–61
 - active-matrix LCD, 1003
 - active-matrix OLED, 1004
 - antireflection coatings, 264, 301
 - axicons, 14, 57, 106, 137
 - backlight, 1002
 - beam combiners, 13
 - beam directors, 14
 - beamsplitters, 13, 63, 247, 263, 268, 301, 522, 539, 549
 - catadioptric, 15
 - circulator, 1173
 - collimators, 9, 15, 799
 - diffraction gratings, 59, 78
 - electro-optic prism, 983
 - fiber couplers, 413
 - fibers, 392, 422–423, 426, 429
 - filter, acousto-optic, 966
 - frequency shifter, acousto-optic, 967
 - graded-index, 22–24, 40, 60, 396
 - integrated, 354, 808
 - isolator, 250, 967, 1167
 - LED optics, 15, 799
 - lenses, 16–18, 57, 58, 319
 - mirrors, 9, 10, 53
 - modulators, acousto-optic, 959
 - passive-matrix LCD, 1002
 - photonic lantern, 414
 - plates, 39, 55
 - polarizers, 217, 253, 520
 - prisms, 13, 14, 56, 57

- resonators, 434, 447, 459, 463, 516
- scanners, acousto-optic, 961
- segmented LCD, 1002
- space switches, acousto-optic, 964
- spatial light modulator, 965, 1002
- spectrum analyzer, AO, 963
- spiral phase plate, 104
- superprism, 1180
- thin films, 264, 301
- waveguide couplers, 376–383
- waveguides, 355, 363, 372, 386
- Optical fiber amplifier, 640–642
 - communications component, 1234
 - compare with SOA, 830
- Optical fiber communications, 1224–1286
 - analog, 1253
 - analog coherent, 1271
 - attenuation, 1246, 1247, 1252
 - attenuation compensation, 1253
 - balanced homodyne receiver, 1268
 - balanced mixer, 1268
 - bit error rate, 1245
 - coherent, 1266–1274
 - coherent receiver advantages, 1269
 - components, 1226–1238
 - direct vs. heterodyne, 1274
 - direct vs. homodyne, 1274
 - dispersion, 1246, 1249, 1252
 - dispersion compensation, 1254, 1255
 - dispersion management, 1255
 - evolution, 1240–1243
 - eye diagram, 1245
 - fibers, 1226–1231
 - heterodyne receiver, 1267
 - heterodyne vs. direct, 1274
 - homodyne BPSK, 1273
 - homodyne OOK, 1272
 - homodyne QPSK, 1273
 - homodyne vs. direct, 1274
 - homodyne vs. heterodyne, 1274
 - introduction to, 1225–1226
 - local oscillator, 1267
 - modulation, 1257–1260
 - multiplexing, 1260–1263
 - networks, 1274–1281
 - optical amplifier, 1234
 - performance, 1243–1246
 - photodetector, 1235–1237
 - photonic integrated circuit, 1238
 - power budget, 1247
 - receiver sensitivity, 1246
 - soliton, 1256
 - SONET standard, 1239, 1276
 - sources, 1232–1234
 - systems, 1238–1257
 - time budget, 1249
- Optical indicatrix, *see* Index ellipsoid
- Optical materials
 - 2D, 745, 780
 - fused silica, 19, 186, 191, 204, 205, 207, 394, 416, 417, 419, 641, 961, 1110
 - GaAs, 207
 - glass, BK7, 1098, 1105, 1107, 1116
 - glass, phosphate, 639, 643
 - glass, phosphosilicate, 643, 692
 - host glass, 640
 - LiNbO₃, 254, 375, 973, 980, 992, 995, 1006, 1036
 - LiTaO₃, 992, 995
 - periodically poled, 1035, 1036
 - quartz, 240, 242, 254, 1015
 - soft glasses, 429
 - TeO₂, 958
 - TMDs, 745, 780
- Optical receiver
 - analog receiver sensitivity, 929–930
 - bipolar-transistor amplifier, 925
 - bit error rate, 911, 932
 - circuit-noise parameter, 923–925
 - digital receiver sensitivity, 931–934
 - FET amplifier, 925
 - on-off keying (OOK), 931
 - resistance-limited, 924
 - sensitivity, 911
 - signal-to-noise ratio, 925–929
 - SNR dependence on APD gain, 928
 - SNR dependence on bandwidth, 928
 - SNR dependence on photon flux, 926
- Optical system, periodic, 33–37, 447–450
 - GRIN plate, 40
 - harmonic trajectory, 35
 - lens sequence, 36
 - lens-pair sequence, 37
 - periodic trajectory, 35
 - ray position, 33
 - resonator, 37, 40
- Organic semiconductors, 742, 876
- Oscillator
 - harmonic, 170, 323, 542, 543, 573, 1072, 1298
 - Lorentz, 186, 1018, 1072
 - optical parametric, 1027, 1057
 - phase-conjugation, 1066
- Paraboloidal
 - approximation, 49
 - mirror, 8

- surface, 86
- wave, 49, 51, 81
- Parametric
 - amplifier, 1027, 1056
 - downconverter, 1027
 - oscillator, 1027, 1057
 - oscillator, doubly resonant, 1058
 - oscillator, singly resonant, 1058
 - processes, 1017
 - switches, 1197
- Paraxial
 - approximation, 9, 27, 50
 - Helmholtz equation, 51, 78
 - imaging system, 31
 - optics, 5, 9, 27–37
 - ray equation, 21, 22, 40
 - rays, 9
 - system, focal length, 31
 - system, focal point, 31
 - system, principal point, 31
 - system, vertex point, 31
 - wave, 50, 1086
 - wave equation, generalized, 1124
- Parseval's theorem, 914, 1288
- Partially coherent light, *see* Coherence
- Pauli exclusion principle, 565, 582, 734
- Pendry, Sir John, 303
- Penetration depth, 308, 312
- Periodic media
 - 2D periodic structure, 292
 - 3D periodic structure, 294
 - Fourier optics, 286–289
 - matrix optics, 280–281
- Periodic table
 - elements, 566, 567
 - semiconductors, 737
- Permeability, magnetic, 163, 167, 343
 - complex, 306, 309–310
 - negative, 306
 - tensor, 343
- Permittivity, electric, 163, 167, 306
 - complex, 183, 198, 306, 309–310
 - effect of electric field, 990
 - effective, 198, 320
 - frequency-dependent, 184
 - in magneto-optic material, 243
 - negative, 306
 - relative, 167
 - tensor, 170, 228, 343
- Perot, Alfred, 433
- Phase
 - mismatching tolerance, 1076
 - sensitive amplifier, 1062
 - shift coefficient, 660
- amplifier, 70
- matching, 288, 1026, 1029–1145
- noise, 680, 843
- spiral, 103, 155
- velocity, 48, 200, 284, 352
- Phosphorescence, 609, 811
- Photoconductors, 875, 883–886
 - detection circuit, 939
 - doped extrinsic, 886
 - extrinsic, 885
 - gain, 884
 - intrinsic, 883
 - noise, 940
 - response time, 885
 - spectral response, 885
- Photodetectors, 871–942
 - array detectors, 907, 1149
 - array readout circuitry, 908
 - avalanche photodiodes, 895–907
 - bolometer, 872
 - CCD readout circuitry, 908
 - charge-coupled device (CCD), 908
 - circuit noise, 922–930
 - CMOS readout circuitry, 909
 - communications component, 1235
 - digital photon-counting device, 906
 - electron-multiplying CCD, 909
 - external photoeffect, 873
 - extrinsic photoconductive, 886
 - focal-plane array (FPA), 907
 - FROG, 1156
 - gain, 879
 - gain noise, 915–921
 - general properties, 876–883
 - Golay cell, 872
 - intensified CCD (ICCD), 909
 - intensity, pulse, 1146–1151
 - intensity-autocorrelation, 1150
 - internal photoeffect, 873
 - introduction to, 872
 - microbolometer, 872, 907
 - microchannel plate, 875
 - minimum-detectable signal, 911
 - negative-electron-affinity, 874
 - noise, 909–923
 - noise-equivalent power, 911
 - optical-pulse, 1146–1158
 - optical-pulse phase, 1152–1156
 - organic, 876
 - performance measures, 910
 - photoconductors, 875, 883–886
 - photodiodes, 887–894
 - photoelectric, 872
 - photoelectric emission, 873–875

- photoemission equation, 873
- photomultiplier, 874, 904
- photon detection efficiency, 876
- photon-number-resolving, 904, 905
- phototube, 874
- plasmonic, 878
- pyroelectric, 872
- QDIP, 886
- quantum efficiency, 876
- QWIP, 886
- Ramo's theorem, 880
- RC time constant, 883
- reach-through APD, 899
- resonant-cavity, 878
- response time, 880
- responsivity, 878
- SACM APD, 899, 902
- SAM APD, 899, 901, 902
- secondary emission, 874
- signal-to-noise ratio, 910, 913, 916
- silicon photomultiplier (SiPM), 905
- single-photon, 904
- specific detectivity, 911
- spectral intensity, pulse, 1151–1152
- spectrogram, pulse, 1156–1158
- streak camera, 1149
- superconducting, 907
- thermal, 872
- thermocouple, 872
- thermopile, 872
- transit-time spread, 880, 939
- transition-edge sensor (TES), 907
- two-photon, 939, 1156, 1162
- vacuum photodiode, 874
- Photodiodes, 887–894
 - p*–*i*–*n* junction, 889
 - p*–*n* junction, 887
 - avalanche, 895–907
 - comparison with APDs, 927
 - depletion layer, 887
 - edge-illuminated, 890, 892
 - evanescently coupled, 890
 - group-IV, 892, 894
 - heterostructure, 891
 - metal–semiconductor, 893
 - modes of operation, 888
 - open-circuit operation, 888
 - photon-trapping microstructures, 891
 - photovoltaic operation, 888
 - response time, 888
 - reverse-biased operation, 889
 - Schottky-barrier, 893, 894
 - short-circuit operation, 888
 - solar cell, multi-junction, 892
- traveling-wave configuration, 890
- Photoelastic
 - effect, 968
 - tensor, 969
- Photoluminescence, 608–612, 813
 - applications, 610
 - multiphoton, 610
 - quantum dots, 580
- Photometry
 - illuminance, 812
 - luminous efficacy, 812
 - luminous flux, 812
 - photopic luminosity function, 812
- Photon, 516–529
 - antibunching, 780
 - at beamsplitter, 522
 - boson, 524, 537
 - energy, 518
 - Gaussian-wavepacket, 527
 - helicity, 524
 - in Fabry–Perot resonator, 555
 - in Gaussian beam, 522
 - in Mach–Zehnder, 526
 - in Young interferometer, 525
 - interference, 525
 - lifetime, 662
 - momentum, 523–524, 554, 555
 - monochromatic, 527
 - optics, 514–541
 - orbital angular momentum, 104, 524
 - polarization, 519
 - polychromatic, 527, 555
 - position, 521
 - position and time, 527
 - spin angular momentum, 524
 - time, 526
 - transmission through polarizer, 520
 - wavepacket, 527
- Photon detectors, *see* Photodetectors
- Photon stream, 529–541
 - number of photons, 531, 532
 - partitioned, 539–541
 - photon flux, 530, 532
 - photon-flux density, 530, 532
 - photon-number statistics, 533–541
 - randomness, 532
 - spectral density, 531
- Photon-number statistics, 533–541
 - Bernoulli, 539
 - Bernoulli trial, 912
 - binomial, 540, 541, 546, 557
 - Bose–Einstein, 536, 537, 539, 556
 - coherent light, 533
 - counting time, 533

- doubly stochastic, 538, 556
- exponential density function, 539
- geometric, 537
- Mandel's formula, 538
- mean, 533, 535
- mean under absorption, 556
- negative-binomial, 556
- noncentral-chi-square density, 656
- noncentral-negative-binomial, 653
- partitioned distribution, 540, 912
- partitioned SNR, 541, 912
- photon number, 533
- photon-number distribution, 533
- Poisson, 534, 544, 555
- random partitioning, 539, 556
- random selection, 539, 912
- signal-to-noise ratio, 535, 911
- sub-Poisson, 546
- thermal light, 536
- uniform, 557
- variance, 535
- Photonic**
 - bandgap, 282, 285, 296
 - integrated circuits, 354, 809, 1176, 1238
 - lantern, 414
- Photonic crystal**, 277–302
 - 2D, 292–294
 - 3D, 294–299
 - band structure, 282, 285, 296
 - bandgap, 282, 285, 296
 - Bloch modes, 277, 1305
 - dispersion relation, 285
 - fabrication, 297, 299
 - fibers, 426–428
 - group velocity, 284
 - holes and poles, 298
 - holes on diamond lattice, 297
 - inverse-opal, 297, 298
 - laser, 860
 - laser array, 861
 - lattice defects, 298
 - metal–dielectric array, 388
 - metamaterial, 256, 334
 - omnidirectional reflection, 290
 - one-dimensional, 277–291
 - optics, 255–302
 - optics, introduction to, 256–258
 - phase velocity, 284
 - point defects, 298
 - projected dispersion diagram, 285
 - silicon, 297
 - soliton generation, 1141
 - switch, photonic, 1200
- thresholdless laser, 861
- waveguide, 385–386
- woodpile, 297
- Yablonovite, 297
- Photorefractivity**, 1005–1009
 - applications, 1009
 - real-time holography, 1009
 - simplified theory, 1006–1009
- Planck**
 - Planck's constant, 518
 - spectrum, 605
- Planck, Max**, 515, 516, 529
- Plane wave**, 47, 111, 113
 - acoustic, 946
 - conjugate, 1045
 - electromagnetic TEM, 175, 307
 - partially coherent, 487
 - pulsed, 1086
 - quasi-plane wave, 407
 - reflection, 221
 - refraction, 221, 238
 - wavefronts, 48
 - wavefunction, 48
- Plasma**
 - frequency, 322
 - wavelength, 322
- Plasmonics**, 320–334, 387
 - LEDs, 796
 - nanolasers, 862
 - photodetectors, 878
 - resonator, 469–470
 - switch, photonic, 1201
 - waveguide, 386–388
- Pockels**
 - coefficient, 978, 1025, 1077
 - effect, 978, 991–994, 1024
 - readout modulator (PROM), 988
- Pockels, Friedrich**, 975
- Poincaré sphere**, 213, 508
- Point-spread function**, 1299
- Poisson, Siméon Denis**, 871
- Polarization**, 211–221
 - p*, 222
 - s*, 222
 - maintaining fiber, 406
 - autocorrelation, 506
 - circular, 213, 253, 509, 524
 - coherency matrix, 507
 - complex envelope, 211, 214
 - complex polarization ratio, 213
 - coordinate transformation, 219
 - cross-correlation, 506
 - degree, 509
 - electric-field vector, 211

- ellipse, 211–212
- Jones matrix, 217–221, 509
- Jones vector, 215–221, 507
- linear, 212, 508, 524
- matrix representation, 215–221, 1302
- mode dispersion, 423
- normal modes, 220, 221
- optics, 209–254
 - optics, introduction to, 210–211
 - orthogonal, 222, 252
 - orthogonal expansion, 216
 - orthogonal Jones vectors, 215
 - parallel, 222
 - partial, 506–510
 - photon, 519
 - Poincaré sphere, 213, 508
 - rotator, 219, 245, 249, 252, 253, 549
 - Stokes parameters, 213, 507
 - transverse-electric, 222, 223
 - transverse-magnetic, 222, 224
 - two-photon, 547
 - unpolarized light, 508
- Polarization devices
 - rotator, 252
- Polarization density, 164, 1017
- Polarization devices, 247–251
 - anti-glare screen, 253
 - cascade, 219, 253, 254
 - circulator, 251
 - coordinate transformation, 219
 - dichroic, 247
 - Faraday rotator, 250, 1173
 - fast and slow axes, 218, 248, 253
 - half-wave retarder, 219, 220, 253
 - intensity control, 249
 - isolator, 250
 - linear-polarizer cascade, 254
 - nonlinear Kerr switch, 1148, 1198
 - nonreciprocal, 250–251
 - normal modes, 220
 - polarizer, 217, 247–248, 253
 - polarizing beamsplitter, 248
 - quarter-wave retarder, 218
 - rotator, 219, 249, 549
 - router, 1184
 - wave retarder, 218, 248, 253
 - wave-retarder cascade, 219, 253
- Polychromatic light, 71–76
 - intensity, 72
- Ponderomotive force, 703, 1142
- Postulates
 - Born postulate, 563
 - Einstein postulates, 591
 - ray optics, 5–8
- wave optics, 43–44
- Power
 - electromagnetic, 165, 172
 - Gaussian beam, 83
 - optical, 44
 - scattered, 194, 195
 - spectral density, 479
- Poynting
 - theorem, 168
 - vector, 165, 173, 312
- Principal
 - axes, 229
 - refractive indices, 229
- Principal point
 - SEFOC lens, 24
 - arbitrary paraxial system, 31
- Prism, 13, 14, 56
 - chirp filter, 1097, 1105, 1161
 - coupler, 329, 352, 377
 - dispersion compensation, 685
 - electro-optic, 983
 - laser-line selector, 677
 - spatial, 116
 - superprism, 1180
- Prokhorov, Aleksandr M., 619
- Propagation
 - along principal axis, 230–231
 - anisotropic medium, 232–233
 - free space, 113–123
 - gain of spatial coherence, 502
 - homogeneous medium, 6
 - partially coherent light, 497–498
 - van Cittert–Zernike theorem, 503
- Pulse, optical
 - attosecond, 1141
 - characteristics, 1079–1083
 - chirp filtering of, 1088–1099
 - chirp parameter, 1082
 - chirped, 1082
 - chirped-Gaussian, 1084–1085
 - complex envelope, 73, 1080
 - compression, 1099, 1109, 1130, 1144
 - detection, 1146–1158
 - dispersion length, 1106
 - down-chirped, 1082
 - Fourier-transform-limited, 1084
 - frequency-to-space mapping, 1101
 - FROG, 1156
 - Gaussian, 1080, 1084–1085, 1161
 - Gaussian beam, 1087, 1120
 - Gaussian, bandwidth-limited, 1084
 - in dispersive media, 199–203
 - instantaneous frequency, 1081
 - intensity autocorrelation, 1150, 1162

- intensity detection of, 1146–1151
- light bullet, 1139
- linear filtering, 1088
- nonseparability, 1117, 1125
- phase detection of, 1152–1156
- plane wave, 73, 1086
- propagation in fiber, 1102–1115
- rectification, 1128
- sech, 1040, 1080, 1133, 1136, 1161
- shaping, 1101–1102
- slowly varying, 1086
- soliton, 1133
- soliton self-frequency shift, 1140
- soliton, spatiotemporal, 1139
- soliton, temporal, 1130–1139
- spatial characteristics, 1086–1088
- spectral intensity, 1080
- spectral intensity detection, 1151
- spectral phase, 1080
- spectral shift, 1117
- spectral width, 1080
- spectrogram, 1083, 1156–1158
- spherical wave, 78, 1086
- SPM, 1129, 1130, 1140
- spread, 201
- streak-camera detection, 1149
- sub-femtosecond, 1141
- supercontinuum light, 1139
- temporal broadening, 1116, 1117
- temporal width, 1080
- three-wave mixing, 1127, 1162
- THz pulse generation, 1128
- time-to-space mapping, 1102
- time-varying spectrum, 1083
- transform-limited Gaussian, 1084
- up-chirped, 1082
- wavepacket, 73
- Pupil function, 138, 141, 500
 - generalized, 143
- Purcell factor, 598, 796, 800, 855, 861
- Quadric representation, 229, 230
- Quantum
 - circuits, 550
 - cutting, 610
 - defect, 634, 690
 - electrodynamics, 4, 515
 - entanglement, 547
 - mechanics, 562
 - optics, 4, 515, 541–550
- Quantum cascade laser (QCL), 851–854
 - heterogeneous, 852
 - single-frequency, 853
 - strained-layer, 853
- tunable, 853
- Quantum dot
 - infrared photodetector (QDIP), 886
- Quantum dots, 579–580, 607, 766
 - applications, 580
 - artificial atoms, 580
 - core–shell, 580
 - excitons, 580, 850
 - fabrication, 579
 - lasers, 850–851
 - LEDs, 807, 814
 - mode-locked lasers, 851
 - photoluminescence, 580
 - self-assembly, 580, 807, 850
 - silicon photonics, 780, 808
 - single-photon emitter, 546, 780
 - SOAs, 829
 - synthesis, 579
- Quantum number
 - azimuthal, 564
 - magnetic, 564
 - orbital angular momentum, 566
 - overall angular momentum, 566
 - principal, 564
 - rotational, 573
 - spin, 564, 566
 - vibrational, 573
- Quantum state, 541–550
 - amplitude-squeezed, 545
 - binomial, 546, 557
 - biphoton, 548
 - coherent, 544
 - entangled, 547
 - Fock, 546
 - intensity-squeezed, 546
 - number, 546
 - phase-squeezed, 545
 - photon-number-squeezed, 546
 - quadrature-squeezed, 544
 - sub-Poisson, 546
 - thermal, 536
 - twin-beam, 548
 - two-photon, 546
- Quantum well, 578, 761–764
 - infrared photodetector (QWIP), 886
 - lasers, 845
 - SOAs, 826–830
- Quantum wire, 579, 765
 - lasers, 849
- Quantum-confined
 - excitons, 779
 - lasers, 844–854
 - structures, 760–766
- Quasi-phase matching, 1034, 1076

- Radar
 - Doppler, 75
 - laser, 789
- Radiometry
 - irradiance, 812
 - radiant flux, 812
- Raman
 - Nath scattering, 957, 973
 - cascaded fiber laser, 692
 - cascaded silicon laser, 692
 - distributed fiber amplifier, 643
 - fiber amplifier, 642
 - fiber laser, 691
 - gain, 1041
 - lumped fiber amplifier, 643
 - scattering, 613
 - silicon laser, 692, 809
 - stimulated scattering, 613, 642, 691, 1140
 - Stokes shift, 643, 691
- Ramo's theorem, 880, 939
- Random light, *see* Statistical optics
- Rate equations
 - amplifier radiation absent, 626
 - amplifier radiation present, 627
 - broadband radiation, 617
 - photon-number, 709
 - population-difference, 710
 - thermal light, 604
- Ray equation, 20–21
 - paraxial, 21
- Ray optics, 3–40
 - introduction to, 4–5
 - postulates, 5–8
 - relation to electromagnetic optics, 4
 - relation to quantum optics, 4
 - relation to wave optics, 4, 26, 42, 52
- Ray-transfer matrix, 27–33
 - 4×4 , 40
 - SEFOC plate, 40
 - air followed by lens, 31
 - arbitrary paraxial system, 31
 - cascade of components, 30
 - determinant, 31
 - free-space, 29
 - inverse, 31
 - lens system, 40
 - parallel transparent plates, 30
 - planar boundary, 29
 - planar mirror, 29
 - skewed rays, 40
 - special forms, 28
 - spherical boundary, 29
 - spherical mirror, 30
- spherical-mirror resonator, 447
- thick lens, 32
- thin lens, 29, 31
- Rayleigh
 - Jeans formula, 463, 606
 - inverse fourth-power law, 194, 417
 - range, 81
 - scattering, 193–197, 416, 612
- Rayleigh, Lord (John William Strutt), 160
- Reciprocal
 - lattice, 292
- Rectification, optical, 1023
 - pulsed, 1128
- Reflectance
 - at boundary, 222–225
 - between GaAs and air, 226
 - between glass and air, 226, 253
 - from a Bragg grating, 950
 - from a plate, 227
 - of a conductive medium, 321
 - power, 226
 - quarter-wave film, 264, 301
- Reflection, 53, 221–227
 - at a dielectric boundary, 7
 - at a DPS-SNG boundary, 310
 - at a metasurface, 342
 - at a mirror, 7
 - at an absorbing boundary, 253
 - Bragg grating, 273
 - Brewster angle, 224, 225, 247
 - circularly polarized light, 253
 - critical angle, 12, 223, 225, 310, 327
 - external, 223, 224
 - frustrated total internal, 329, 378
 - internal, 223, 225
 - omnidirectional, 290, 302
 - phase shift, 224
 - total internal, 12, 13, 15, 18, 223, 253, 353, 392, 698
 - transverse-electric polarization, 223
 - transverse-magnetic polarization, 224
- Refraction, 53, 221–227
 - all-angle, 320
 - at a dielectric boundary, 7, 15
 - at a hyperbolic medium, 319
 - at a metasurface, 342
 - at a spherical boundary, 14
 - at normal incidence, 346
 - Brewster angle, 253
 - conical, 254
 - double, 238–239, 254
 - external, 11
 - internal, 11
 - negative, 314–317

- nonlinear, 1038
- rays in anisotropic media, 239, 254
- transverse-electric polarization, 223
- transverse-magnetic polarization, 224
- without reflection, 345
- Refractive index, 5, 168, 183
 - air, 208
 - anisotropic media, 228–230
 - extraordinary, 229, 233, 236
 - frequency-dependent, 184
 - group, 201
 - negative, 308
 - optical materials, 184, 191
 - ordinary, 229, 233, 236
 - resonant medium, 189
 - Sellmeier equation, 191
- Resolution
 - acousto-optic filter, 967
 - acousto-optic scanner, 961
 - electro-optic scanner, 983
 - liquid-crystal display, 1003
 - multiphoton lithography, 611
 - multiphoton microscopy, 611
 - optical-pulse detection, 1148
 - routing device, 1182
 - wavelength demultiplexer, 1184
- Resonant medium, 186
 - anharmonic oscillator, 1071–1073
 - Lorentz oscillator, 186, 1018, 1072
- Resonator
 - g -parameters, 448
 - axial modes, 456
 - bow-tie, 439–440
 - circular (2D), 460–461, 469
 - cold, 662
 - concentric, 449
 - conditionally stable, 448
 - confinement condition, 448–450, 453
 - confocal, 449
 - diffraction loss, 457, 458, 1304
 - energy per mode, 538
 - Fabry–Perot, 69, 265, 436, 661
 - fiber-ring, 434
 - finesse, 69, 266, 441
 - finite apertures, 457, 1304
 - free spectral range, 267, 438, 446
 - frequencies, 437, 439, 446, 460
 - guided-wave, 434, 471
 - integrated-optic-ring, 434, 692
 - losses, 440
 - microdisk, 464
 - micropillar, 464
 - microresonator, 463–468
 - microring, 1180
 - microsphere, 464
 - microtoroid, 464
 - modal density (1D), 440
 - modal density (2D), 460
 - modal density (3D), 462–463
 - modal volume, 435
 - modes, 1304
 - modes, standing wave, 437, 471
 - modes, traveling wave, 438
 - multiple microring, 1181
 - nanodisk, 469
 - nanoresonator, 469–470
 - nanosphere, 330–332, 470
 - number of modes, 472
 - optics, 433–472, 661
 - periodic optical system, 37, 40, 448
 - photonic modes, 469
 - photonic-crystal, 464, 468
 - planar-mirror, 436–446
 - plano-concave, 453
 - plasmonic, 330–334, 469
 - quality factor, 435, 445, 708
 - rectangular (2D), 459–460
 - rectangular (3D), 461–465, 517, 1305
 - ring, 434, 439–440
 - size vs. resonance wavelength, 435
 - spectral width, 440
 - spherical-mirror, 447–458
 - stability diagram, 449, 471
 - stable, 448
 - symmetric, 449
 - transmittance, 729
 - transverse modes, 456
 - traveling wave, 439
 - unstable, 448, 471
 - whispering-gallery modes, 461
- Resonator, spherical-mirror, 447–458
 - axial modes, 456
 - free spectral range, 455, 456
 - Gaussian modes, 451
 - Hermite–Gaussian modes, 455
 - modes, 450–458
 - ray-transfer matrix, 37, 447, 448
 - resonance frequencies, 455, 456
 - symmetric, 449, 453, 471, 472
 - transverse modes, 456
- Responsivity
 - avalanche photodiode, 898
 - differential, 837
 - LD, 839
 - LED, 801, 839
 - photodetector, 878, 1146
 - SLED, 839
- Retarder, 218, 248

- half-wave, 219, 220, 253
- quarter-wave, 218, 254
- quartz, 254
- Ring
 - aperture, 67, 118, 159
 - benzene, 742
 - network, 1275
 - resonator, 434, 439–440
- Rotator
 - Faraday, 250, 1173
 - nonreciprocal polarization, 251, 1173
 - polarization, 245, 249, 252
- Router, passive optical, 1178–1187
 - add-drop multiplexer, 1179, 1279
 - arrayed waveguides, 1182, 1223
 - broadcast-and-select, 1179
 - demultiplexer, 1179
 - intensity-based, 1185
 - introduction to, 1164–1165
 - Mach–Zehnder interferometer, 1181
 - multipath interferometer, 1183
 - multiplexer, 1179
 - phase-based, 1185
 - polarization-based, 1184
 - waveguide grating, 1182
 - wavelength-based, 1179–1184
 - wavelength-division multiplexer, 1179
- Russell, Philip St John, 1224
- Saturable absorber, 649
 - bistable device, 1217
- Scalar wave optics, *see* Wave optics
- Scanner
 - acousto-optic, 961
 - electro-optic, 983
 - holographic, 117
- Scattering, 612–614
 - and absorption, 198–199
 - and attenuation, 198, 416, 432
 - anti-Stokes, 613
 - Bragg diffraction, 953, 973
 - Brillouin, 613
 - CARS, 614
 - coefficient, 198
 - Debye–Sears, 957, 973
 - dielectric nanosphere, 196–197
 - efficiency, 196
 - elastic, 192–197
 - Huygens–Fresnel principle, 193
 - Maxwell–Garnett mixing rule, 199
 - metallic nanosphere, 330–332
 - Mie, 197, 613
 - quasi-static approximation, 196, 197
 - Raman, 613
 - Raman–Nath, 957, 973
 - Rayleigh, 193–197, 416, 432, 612
 - small scatterers, 193
 - stimulated Brillouin, 614, 644, 692
 - stimulated Raman, 613, 642, 691, 1140
 - Stokes, 613
 - strong, 196
 - volume fraction, 198
 - weak, 192–194
- Scattering matrix, 259–265, 549
 - beamsplitter, 263
 - dielectric boundary, 262, 264
 - dielectric slab, 263, 265
 - homogeneous medium, 260
 - lossless medium, 261
 - lossless symmetric system, 262
 - relation to wave-transfer matrix, 260
- Schawlow, Arthur, 657, 1015
- Schrödinger equation
 - nonlinear, 1040, 1135, 1138
 - time-dependent, 562, 1304
 - time-independent, 542, 563, 1304
- Schultz, Peter C., 391
- Second-harmonic generation, 730, 1021, 1049, 1051
 - efficiency, 1022, 1052
 - phase mismatch, 1053
 - switch, 1147
- Self-focusing, 1039
- Self-phase modulation, 425, 1038
 - in supercontinuum generation, 1140
 - pulse, optical, 1129, 1130
- Sellmeier equation, 191, 781
- Semiconductor optical amplifiers, 817
 - bandwidth, 819, 869
 - compare with OFAs, 830
 - double-heterostructure, 825
 - gain, 818
 - gain coefficient, 820
 - heterostructures, 825
 - peak gain coefficient, 821, 869
 - pumping, 822
 - quantum-dot, 829
 - quantum-well, 826–830
 - SLEDs, 830
 - switch, photonic, 1193, 1196
 - waveguide, 829
- Semiconductors, 577–580
 - k*-selection rule, 770
 - p*–*i*–*n* junction, 759, 889
 - p*–*n* junction, 756, 887
 - p*–*n* junction, biased, 757
 - absorption, 768, 777

- AlGaAs, 806
 AlGaN, 807
 AlInGaN, 808
 AlInGnP, 806
 allotropes, 743
 alloy broadening, 794
 Auger recombination, 752
 bandgap energy, 576, 733, 738
 bandgap wavelength, 738, 768
 bowing parameter, 785
 Brillouin zone, 735
 bulk, 578, 766–778
 carrier concentrations, 748, 751
 carrier generation, 752
 carrier injection, 753
 carrier recombination, 752
 carriers, 734
 degenerate, 750
 density of states, 745
 density of states, joint, 770
 depletion layer, 756, 887
 direct-bandgap, 737
 dopants, 741
 doped extrinsic, 886
 drift velocity, 880
 effective mass, 736
 electroluminescence, 789–794
 electron affinity, 873
 elemental, 737
 energy bands, 577, 733, 1305
 energy–momentum relations, 735
 excitons, 767, 784, 810, 811, 1010
 extrinsic, 741
 Fermi function, 746
 Fermi inversion factor, 777
 fundamentals, 731–766
 GaAs, 805
 GaAsP, 805
 gain coefficient, 776
 GaN, 807
 heterojunction, 759
 II–VI materials, 740
 III–nitride materials, 738, 807–808
 III–V materials, 738–739, 803–808
 impact ionization, 876, 895
 indirect-bandgap, 737
 InGaAs, 805
 InGaAsP, 805
 InGaAsSb, 806
 InGaN, 807
 interaction with light, 766–781
 internal efficiency, 754
 intrinsic, 741
 IV–VI materials, 741
 Kronig–Penney model, 733
 law of mass action, 750
 minibands, 579, 764, 779, 852
 mobility, 880
 multiquantum-well, 764
 nanocrystals, 579
 nonradiative recombination, 752
 occupancy probabilities, 746, 773
 optics, 766–786
 organic, 742
 periodic table, 737
 photoconductors, 875, 883–886
 photoemission, 873
 quantum dots, 579, 766
 quantum wells, 578, 761–764
 quantum wires, 579, 765
 quantum-confined, 760, 779
 quasi-equilibrium, 751
 recombination coefficient, 752
 recombination lifetime, 753
 refractive index, 781
 SESAM, 719
 Shockley equation, 758
 Si photonics, 375
 SiC, 737
 silicon photonics, 692, 780, 808,
 1238
 superlattice, 579, 764, 779, 852
 transition probabilities, 774
 Vegard’s law, 739, 785
 Semimetals
 band structure, 577, 740, 741
 graphene, 744
 massless Dirac fermions, 744
 Shockley, William B., 731
 Shot noise, 518, 703, 912, 913
 Silicon photonics, 375, 692, 808, 1176
 direct-mounting integration, 809
 flip-chip integration, 809
 heteroepitaxy, 809, 859
 heterogeneous integration, 809
 hybrid approach, 809
 microring laser, 859
 OEIC, 1238
 PIC, 809, 1238
 PLC, 1238
 quantum dots, 780
 Single-mode
 fiber, 405
 waveguide, 359, 366
 Skin depth, *see* Penetration depth
 Slow light, 204
 Snell’s law, 54, 184, 221
 at a boundary, 7

- at a metamaterial boundary, 346
- at a metasurface, 342
- modified, 238, 342
- negative refractive index, 307, 314
- proof, 8
- Solids, 575–580
 - covalent, 575
 - doped dielectric media, 568
 - ionic, 575
 - metallic, 576
 - molecular, 576
 - van der Waals, 573, 576, 745
- Soliton
 - N -soliton wave, 1136
 - collision, 1199
 - condition, 1132
 - dark, 1138
 - directional-coupler router, 1187
 - envelope, 1133
 - fundamental, 1135, 1162
 - generation, 1137
 - higher-order, 1136
 - interaction, 1137
 - laser, 1138
 - optical fiber communications, 1256
 - period, 1136
 - photonic-crystal, 1141
 - sech pulse, 1133, 1136
 - self-frequency shift, 1140
 - solitary wave, 1131
 - spatial, 1039
 - spatial–temporal analogy, 1138
 - spatiotemporal, 1139
 - switch, photonic, 1199
 - temporal, 1130–1139
 - vector, 1200
- SONET, 1239, 1276
- Sonoluminescence, 607, 608
- Spatial
 - coherence, 483
 - dispersiveness, 241
 - filter, 141, 151
 - frequency, 111, 113
 - harmonic function, 113
 - hole burning, 673
 - Lambertian pattern, 799
 - laser emission pattern, 675
 - LD emission pattern, 841
 - LED emission pattern, 799
 - solitons, 1039
 - spectral analysis, 114
- Spatial light modulator
 - acousto-optic, 965
 - bistable, 1220
- digital micromirror device, 1190
- electro-optic, 987–989
- liquid-crystal, 1002–1005
- optically addressed, 987, 1004
- parallel-aligned (PAL-SLM), 1005
- Pockels readout optical (PROM), 988
- Speckle, 406
- Spectral
 - density, 479
 - hole burning, 651
 - packet, 596
 - width, 481
- Spectrogram, 1083, 1156–1158
- Wigner distribution function, 1157
- Spectrum analyzer
 - acoustic, 963
 - interferometric, 1151
 - optical, 1151
- Speed of light, 5, 42, 43, 163, 167, 184, 200, 204, 516, 1016
- Spherical wave, 48, 177
 - complex amplitude, 77
 - conjugate, 1045
 - intensity, 77
 - paraboloidal approximation, 49
 - partially coherent, 488
 - pulsed, 1086
 - reflection, 78
 - wavefronts, 48
 - wavefunction, 48
- Spin
 - allowed transitions, 609, 811
 - forbidden transitions, 609, 811
 - orbit coupling, 565, 566, 811
 - spin coupling, 565
 - angular momentum, 524
 - electron, 564, 746
 - multiplicity, 566
 - photon, 516, 524, 746
 - singlet state, 566, 575, 609, 811
 - triplet state, 566, 575, 609, 811
- Spontaneous emission
 - atoms, 583, 587–588
 - enhanced, 464, 597, 796, 800
 - inhibited, 464, 617
 - occupancy probability, 773
 - peak rate, 786
 - Purcell factor, 598, 796, 855, 861
 - semiconductors, 769
 - spectral intensity, 775
 - transition rate, 592, 775
- Stark effect, 568, 601
 - light shift, 600
 - quantum-confined, 1010

- Statistical optics, 473–513
 gain of spatial coherence, 502
 imaging with incoherent light, 499
 interference, 489
 interferometry, 490, 493, 550
 introduction to, 474–475
 longitudinal coherence, 487
 optical intensity, 475
 partial polarization, 506
 quantum interferometry, 550
 spatial coherence, 483
 spectrum, 476
 temporal coherence, 476
 transmission of random light, 497
- Step-index fiber, 393–396, 398–405, 408
- Stimulated Brillouin scattering, 614, 644
- Stimulated emission
 atoms, 585, 589–593
 occupancy probability, 773
 semiconductors, 769
 semiconductors, indirect-gap, 772
 transition rate, 592, 775
- Stimulated Raman scattering, 613, 642, 691, 1140
- Stokes
 parameters, 214, 216, 507
 vector, 214
- Stokes, George Gabriel, 210
- Strain
 sensor, 1013
 tensor, 968
- Sum-frequency generation, 1027, 1197
- Supercontinuum generation, 1139
- Superlattice, 579, 764, 779, 852
 quantum cascade laser, 852
- Superluminescent diodes (SLEDs), 830
 compare with LDs, 839, 841
 compare with LEDs, 839, 841
 light-current curve, 839
- Surface plasmon
 resonance spectroscopy, 329
 resonance, 330
- Surface plasmon polariton, 326
 at DPS-SNG boundary, 311, 351
 at metal–dielectric boundary, 326
 nanolaser, 862
 surface-charge wave, 311
- Susceptibility, electric, 166
 complex, 181
 frequency-dependent, 184
 resonant medium, 188
 tensor, 170
- Switch
 acousto-optic, 959
 electro-optic, 985
 electroabsorption, 1010
 ferroelectric liquid crystal, 1001
 waveguide, 381
- Switch, photonic, 1187–1211
 acousto-optic, 964, 1194
 all-optical, 1196–1211
 architectures, 1187
 Banyan switch, 1210
 buffer, 1209
 characteristics, 1188, 1196
 circuit switching, 1209
 configurations, 1189
 electro-optic, 1192
 energy required, 1202
 Franz–Keldysh effect, 1193
 FWM, 1199
 heat dissipation, 1203
 implementations, 1188
 introduction to, 1164–1165
 liquid-crystal, 1194
 magneto-optic, 1195
 mechano-optic, 1190
 MEMS, 1190
 nonlinear Kerr, 1148, 1198
 nonlinear optical retardation, 1198
 nonlinear Sagnac interferometer, 1201
 opto-optic, 1196–1211
 optoelectronic, 1188
 optomechanical, 1190
 packet, 1209
 parametric, 1197
 photonic-crystal, 1200
 plasmonic, 1201
 programmable delay, 1209
 QCSE, 1193
 quantum limit, 1202
 quantum-confined Stark effect, 1010
 ROADM, 1204, 1280
 second-harmonic generation, 1147
 semiconductor, 1193
 SFG, 1197
 SOA, 1193, 1196
 soliton, vector, 1200
 soliton-collision, 1199
 space, 964, 1187–1203
 space-wavelength, 1204
 switching time, 1190, 1201
 thermo-optic, 1195
 time–space–time, 1207
 time-division demultiplexer, 1207
 time-division multiplexer, 1207
 time-domain, 1206–1209
 time-slot interchange, 1208, 1223

- TOAD, 1201
- wavelength converter, 1205
- wavelength selector, 1203
- wavelength-channel interchange, 1204
- wavelength-selective, 1203–1206
- XGM, 1196
- XPM, 1197–1199

- Tail
 - band, 750, 821, 870, 1010
 - Fermi, 748
 - Urbach, 778, 1010
- Talbot effect, 135
- TEM wave, 175, 307, 355, 506
- Temperature
 - BEC formation, 602
 - blackbody spectrum, 605
 - correlated color, 812, 816
 - Doppler cooling limit, 600
 - earth, 606
 - single-photon recoil limit, 600
 - sub-recoil cooling, 600
 - sun, 606
 - thermographic images, 606
- Tensor
 - conductivity, 882
 - constraints, 969, 1066, 1074
 - elasto-optic, 969
 - electric permittivity, 170, 228, 343
 - electric susceptibility, 170
 - first-rank, 228
 - fourth-rank, 969, 990, 1066
 - geometrical representation, 228
 - impermeability, 230, 989
 - index ellipsoid, 230
 - linear electro-optic, 990
 - magnetic permeability, 343
 - photoelasticity, 969
 - quadratic electro-optic, 990
 - quadric representation, 229, 230
 - second-order nonlinearity, 1066
 - second-rank, 170, 228–230, 343, 882
 - strain, 968
 - strain-optic, 969
 - third-order nonlinearity, 1066
 - third-rank, 990, 1066
 - zeroth-rank, 228
- Terahertz
 - frequencies, 42, 853, 854, 1128
- Term symbol
 - actinide metals, 569
 - atoms, 566
 - He, 566
 - lanthanide metals, 569
- occupied subshells, 566
- rare-earth elements, 569
- transition metals, 569
- Thermal light, 602–607
 - blackbody radiation, 602
 - rate equation, 604
 - Rayleigh–Jeans formula, 606
 - spectrum, 604
 - Stefan–Boltzmann law, 606, 618
 - thermography, 606
 - Wien’s law, 617
- Thermo-optic effect, 1195, 1198
- Third-harmonic generation, 1037, 1063
- Three-wave mixing, 545, 1025, 1043, 1050, 1061, 1066, 1073, 1076
 - pulsed, 1127, 1162
- Time
 - varying spectrum, 1083
 - lens, 1113, 1162
- Townes, Charles H., 619
- Transfer function, 1297, 1300
 - 4-f imaging system, 139
 - free space, 119–122, 316
 - single-lens imaging, 144–145
- Transformation optics, 343–348
 - cylindrical focusing, 346
 - refraction at normal incidence, 346
 - refraction without reflection, 345
 - transformation principle, 344–347
- Transition
 - absorption, 584, 589
 - excitonic, 767, 779
 - free-carrier, 767
 - impurity-to-band, 767
 - interband, 766, 779
 - intersubband, 779
 - intraband, 767
 - miniband, 779
 - phonon, 767
 - spontaneous, 583, 587
 - stimulated, 585, 589
- Transmittance
 - biprism, 57
 - complex-amplitude, 54, 222–225
 - diffraction grating, 59
 - Fabry–Perot, 266–268
 - Fresnel biprism, 57
 - graded-index plate, 60
 - optical components, 54, 497
 - plate of varying thickness, 55
 - power, 226
 - prism, 56
 - thin lens, 57
 - transparent plate, 55

- Tyndall, John, 353
- Ultrafast optics, 1078–1162
 introduction to, 1079
 linear, 1115–1125
 nonlinear, 1126–1145
 pulse characteristics, 1079–1088
 pulse compression, 1088–1102
 pulse detection, 1146–1158
 pulse propagation in fibers, 1102
 pulse shaping, 1088–1102
- Ultraviolet
 EUV band, 697
 frequencies, 42
 UVA band, 42, 808
 UVB band, 42
 UVC band, 42, 808
 VUV band, 42
 wavelengths, 42
- Uncertainty relation
 duration–bandwidth, 1290
 field quadratures, 543
 Heisenberg, 528, 543, 1291
 position–momentum, 543
 time–energy, 527, 555
- Undulator, 702
- Uniaxial crystal, 229, 233, 236, 317–320
- Units, radiometric and photometric, 812
 illuminance, 812
 irradiance, 812
 luminous efficacy, 812
 luminous flux, 812
 radian flux, 812
- Up-conversion, 1027, 1054, 1055
 fluorescence, 611
- Vacuum state, 518, 544
- van Cittert–Zernike theorem, 503–505
- VCSELs, 856–858
- VECSELs, 721, 859
- Vector
 beam, 179, 180
 potential, 177
- Velocity
 group, 200, 204, 284, 352, 360, 370, 404, 412
 information, 204
 phase, 48, 200, 204, 284, 352
- Verdet constant, 243
- Veselago, Victor Georgievich, 303
- Visibility, 78, 490
- Visible
 frequencies, 42
 wavelengths, 42
- Vortex, optical, 104
 laser, 860
 phase singularity, 104
 topological charge, 104, 155
- Wave
 -particle duality, 521
 acoustic plane, 946
 beating, 74, 967, 1153, 1267
 complex amplitude, 46
 complex analytic signal, 71
 complex envelope, 47, 80, 175
 complex representation, 45
 complex wavefunction, 45, 72
 conjugate, 78, 1045
 cylindrical, 78
 evanescent, 120, 146, 224, 316, 368
 in a GRIN slab, 78
 localized, 523
 monochromatic, 44–52
 nondiffracting, 136
 paraboloidal, 49, 51, 81
 paraxial, 50, 1086
 partially coherent, 487, 488
 plane, 47, 111, 113
 polychromatic, 71–76
 pulsed, 73, 78, 1086
 quasi-monochromatic, 72
 quasi-plane, 407
 restoration, 1046
 retarder, 218, 248
 retarder, dynamic, 980
 retarder, liquid-crystal, 997–1001
 retarder, voltage-controlled, 998
 spherical, 48, 77, 78
 standing, 78
 stationary, 136
 wavefronts, 47
 wavefunction, 43, 45, 71
 wavelength, 47
- Wave equation, 43, 45, 72
 diffusion equation, 1111
 generalized paraxial, 1124
 in free space, 163
 in homogeneous medium, 171
 in inhomogeneous medium, 169, 953
 in medium, 167
 in nonlinear dispersive medium, 1133
 in nonlinear medium, 1019, 1047
 SVE, 1111
 SVE, nonlinear, 1133
- Wave optics, 41–78
 introduction to, 42–43
 postulates, 43–44

- vs. electromagnetic optics, 180
- vs. ray optics, 52
- Wave-transfer matrix, 258–265, 1303
 - antireflection film, 264
 - beamsplitter, 263
 - cascade of elements, 259
 - dielectric boundary, 262, 264
 - dielectric slab, 263, 265
 - homogeneous medium, 260
 - lossless medium, 261
 - lossless system, 262
 - relation to scattering matrix, 260
- Wavefronts
 - anisotropic medium, 234–237
 - helical, 103, 155, 524
 - plane-wave, 48
 - spherical-wave, 48
- Wavefunction
 - complex, 45, 716, 1080, 1158
 - electron, 562, 582, 734, 1291, 1304
 - entangled-photon, 547
 - harmonic-oscillator, 542
 - plane-wave, 48
 - quantum mode, 543
 - single-photon, 521
 - spherical-wave, 48
 - two-photon, 546
- Waveguide, optical, 354
 - arrays, 383
 - asymmetric planar, 372
 - bounce angles, 357, 365, 390
 - Bragg-grating, 385
 - channel, 374
 - cladding, 363
 - confinement factor, 369, 390
 - core, 363
 - coupled-mode theory, 378–384
 - couplers, 378–383
 - coupling, 376–384, 390, 985
 - cutoff, 359, 366, 390
 - cylindrical, 392
 - dispersion relation, 359, 370
 - evanescent wave, 368
 - extinction coefficient, 368
 - fiber, 392
 - field distributions, 358, 367, 389, 390
 - GaAs/AlGaAs, 375
 - glass, 375
 - Goos–Hänchen effect, 371
 - group velocity, 360, 370
 - InGaAsP, 375
 - input coupling, 376
 - LiNbO₃, 375
 - materials, 375
- metal–insulator–metal, 387
- metal–slab, 388, 390
- modes, 355–357, 363–366
 - multimode fields, 362
 - number of modes, 359, 366, 367, 390
 - numerical aperture, 366
 - optical-power flow, 359, 363
 - periodic, 384
 - photonic-crystal, 385–386
 - planar dielectric, 363–372, 389, 390
 - planar-mirror, 355–363, 1305
 - plasmonic, 386–388
 - power-transfer ratio, 381
 - propagation constants, 357, 365
 - rectangular dielectric, 373, 390
 - rectangular mirror, 372
 - side coupling, 377
 - silica-on-silicon, 375
 - silicon-on-insulator, 375
 - single-mode, 359, 366, 390
 - switch, 381
 - transfer distance, 378, 381, 985
 - two-dimensional, 372–375
- Wavelength, 47
 - γ -ray, 697
 - division multiplexer, 1179
 - activation, 885
 - bandgap, 738, 768
 - converter, 1205
 - de Broglie, 601, 761
 - infrared, 42, 853
 - laser, 644, 706
 - laser amplifier, 644
 - plasmon, 312
 - ultraviolet, 42, 697
 - visible, 42
 - X-ray, 697
 - zero-dispersion, 1140
- Wavenumber, 48, 173
 - complex, 182
- Wavepacket, 73
 - mode, 527
 - random sequence, 482
 - single-photon, 527, 594
 - velocity, 360
- Wavevector, 47
- Width of a function
 - 1/e-, 1292
 - 3-dB, 1292
 - FWHM, 1292
 - Gaussian, 1290–1292
 - measures of, 1290–1293
 - power-equivalent, 1291
 - power-RMS, 1290

root-mean-square (RMS), 1290
Wiener–Khinchin theorem, 480, 512
Wigner distribution function, 1157
WOLED, 810, 816, 1002
Wolf, Emil, 473

X-ray
energies, 697
hard-X-ray (HXR) band, 697
imaging, 705
optical components, 698
soft-X-ray (SXR) band, 697
wavelengths, 697

Yablonovitch, Eli, 255

Yablonovite, 297

Young, Thomas, 41

Zeeman effect, 568, 599, 601

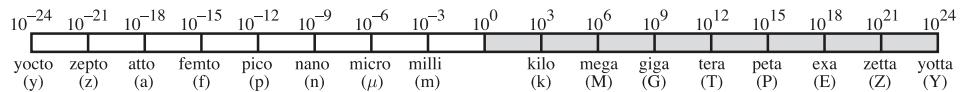
Zero-point energy, 518, 536, 573, 586

Zone plate, Fresnel, 67, 118

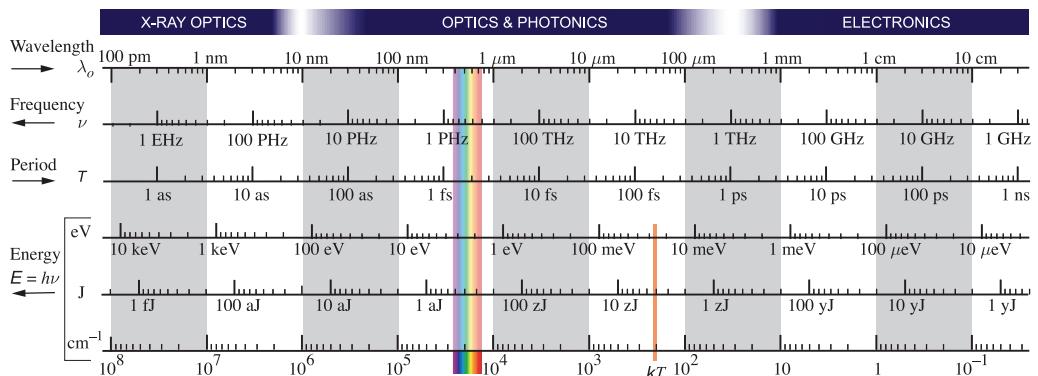
USEFUL CONSTANTS

Speed of light in free space	c_o	2.9979×10^8	m/s	Planck's constant	h	6.6261×10^{-34}	J · s
Permittivity of free space	ϵ_o	8.8542×10^{-12}	F/m	Electron charge	e	1.6022×10^{-19}	C
Permeability of free space	μ_o	1.2566×10^{-6}	H/m	Electron mass	m_0	9.1094×10^{-31}	kg
Impedance of free space	η_o	376.73	Ω	Boltzmann's constant	k	1.3807×10^{-23}	J/°K

PREFIXES FOR UNITS

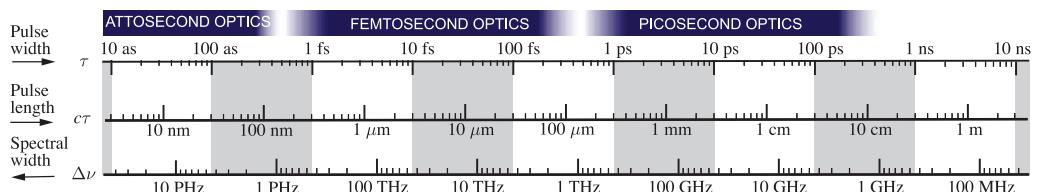


THE PHOTON

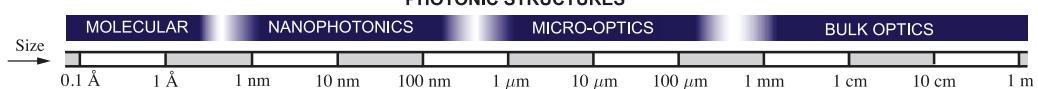


A photon of free-space wavelength $\lambda_o = 1 \mu\text{m}$ has frequency $\nu = 300 \text{ THz}$, period $T = 3.33 \text{ fs}$, and energy $E = 1.24 \text{ eV} = 199 \text{ zJ} = 10^4 \text{ cm}^{-1}$. At room temperature ($T = 300^\circ \text{ K}$), the thermal energy $kT = 26 \text{ meV} = 4.14 \text{ zJ} = 209 \text{ cm}^{-1}$.

OPTICAL PULSES



PHOTONIC STRUCTURES



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Fundamentals of Photonics, Third Edition is a self-contained and up-to-date introductory-level textbook that thoroughly surveys this rapidly expanding area of engineering and applied physics. Featuring a blend of theory and applications, coverage includes detailed accounts of the primary theories of light, including **ray optics**, **wave optics**, **electromagnetic optics**, and **photon optics**, as well as the **interaction of light with matter**. Presented at increasing levels of complexity, preliminary sections build toward more advanced topics, such as **Fourier optics and holography**, **photonic-crystal optics**, **fiber and guided-wave optics**, **LEDs and lasers**, **acousto-optic and electro-optic devices**, **nonlinear optical devices**, **ultrafast optics**, **optical interconnects and switches**, and **optical fiber communications**. The third edition features an entirely new chapter on the **optics of metals and plasmonic devices**. Each chapter contains highlighted equations, exercises, problems, summaries, and selected reading lists. Examples of real systems are included to emphasize the concepts governing applications of current interest. Each of the chapters of the second edition has been thoroughly updated.

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